



NIST Overview

MEMS and Nanotechnology

***National Institute of Standards and Technology
Semiconductor Electronics Division
Department of Commerce***



Department of Commerce



Donald Evans
Secretary

**Secretary
Deputy Secretary**

**National Oceanic
and Atmospheric
Administration**

**Patent and
Trademark Office**

**National
Telecomm. & Info.
Administration**

(Other bureaus)

**Technology
Administration**

**National Technical
Information
Service**

**Office of
Technology Policy**

**National Institute
of Standards and
Technology**



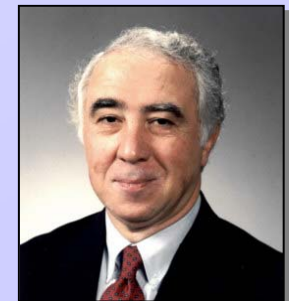
Dr. Samuel Bodman
Deputy Secretary



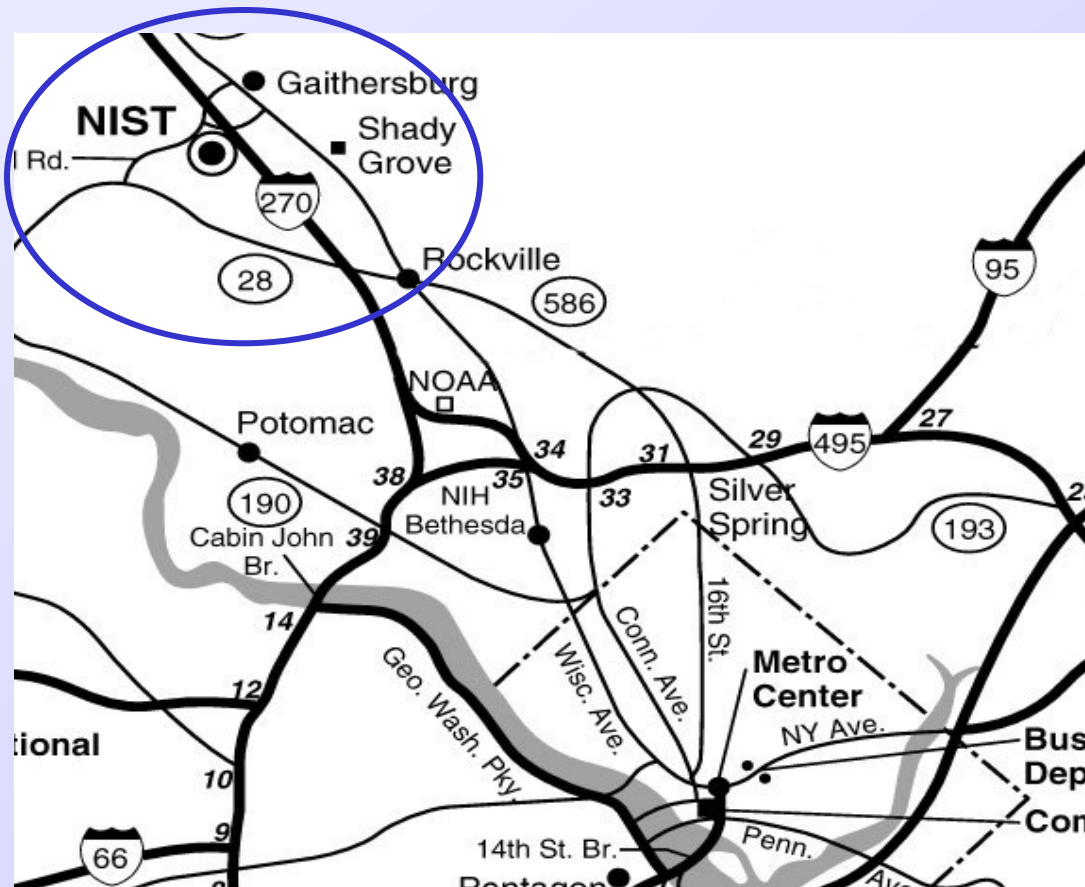
Phillip Bond
Under Secretary



Dr. Arden Bement
Director



Dr. Hratch Semerjian
Deputy Director (Acting)



NIST Has Two Campuses...

Gaithersburg, MD



Boulder, CO



..and two joint Institutes

CARB
University of Maryland



JILA
University of Colorado

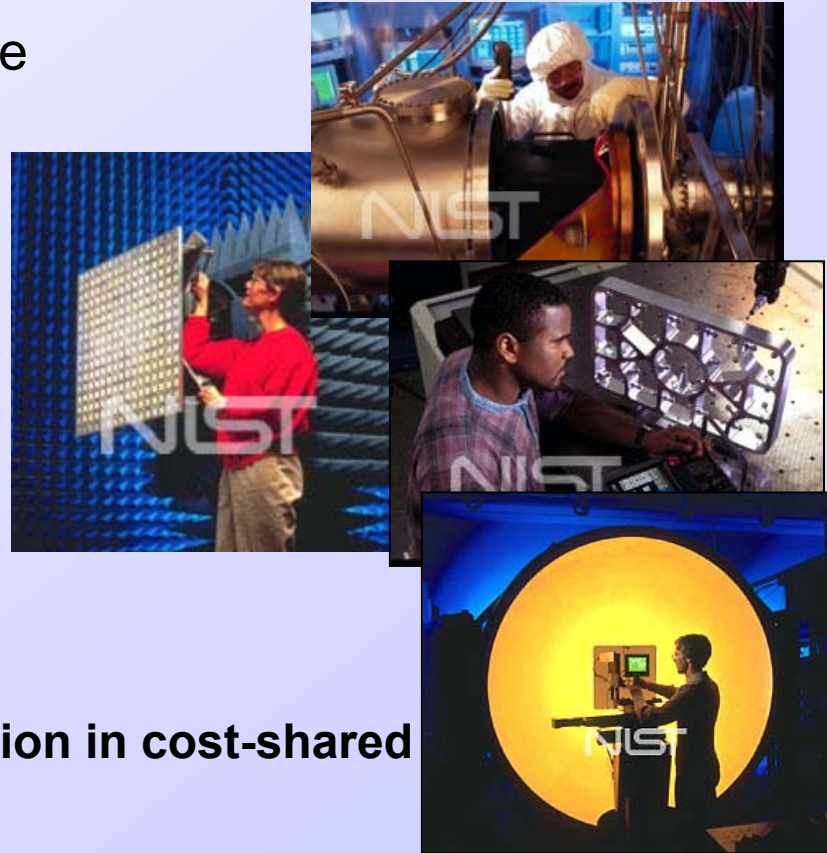


NIST: A Unique Mission and Assets

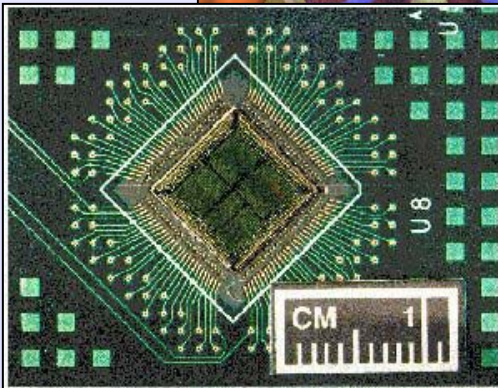
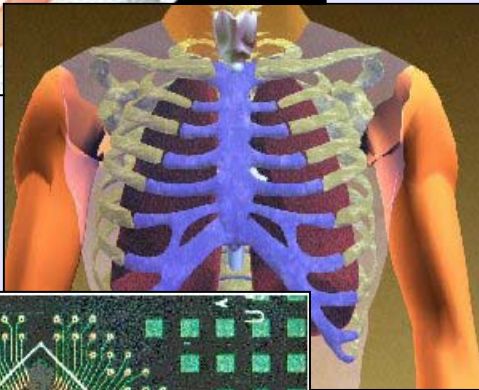
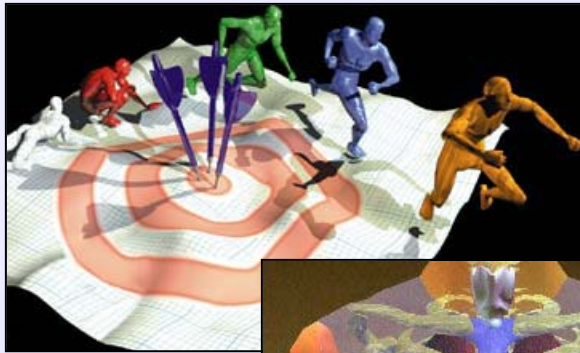
NIST's mission is to develop and promote measurement, standards, and technology to enhance productivity, facilitate trade, and improve the quality of life.

NIST Assets Include:

- 3,000 employees
- 1,600 associates
- \$825 million FY 2003 operating budget
- Advanced Technology Program -- \$4 billion in cost-shared partnerships with industry since 1990
- Manufacturing Extension Partnership -- 400 centers nationwide to help small manufacturers
- Baldrige National Quality Award
- NIST Laboratories -- National measurement standards



NIST Advanced Technology Program

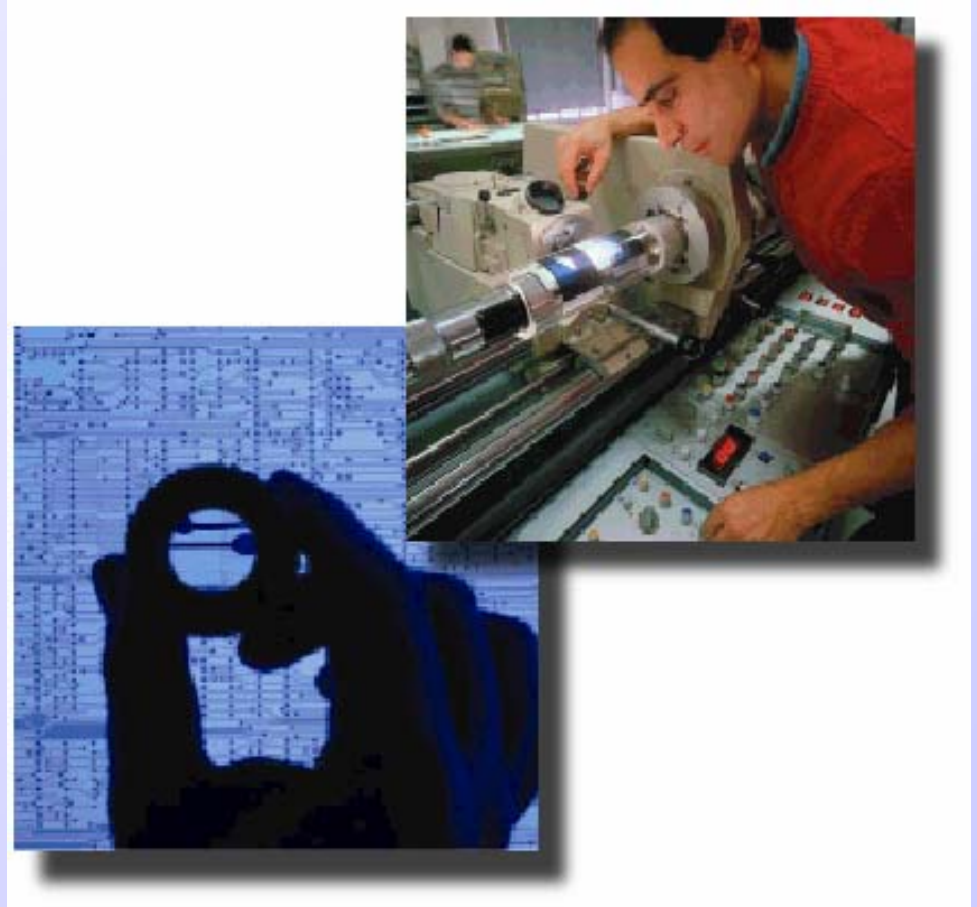


- **Co-funding of private sector R&D to accelerate the development of high-risk, broadly enabling technologies.**
- **Auto Body Consortium - improved fitting of parts to save money for manufacturers and consumers**
- **Tissue Engineering - new materials to repair damaged ligaments and tendons: several billion dollar impact**
- **“DNA Chips” - new technology for cheap, rapid genetic analysis**

www.atp.nist.gov

Manufacturing Extension Partnership

- Nationwide network providing hands-on help to smaller manufacturers to become globally competitive
- **Business assistance**
 - Quality management
 - Human resource development
 - Financial planning
 - Other services
- **Technical assistance**
 - E-commerce
 - Process improvement
 - Plant layout
 - Product development
 - Energy audits
 - Other services



www.mep.nist.gov

Baldrige National Quality Program

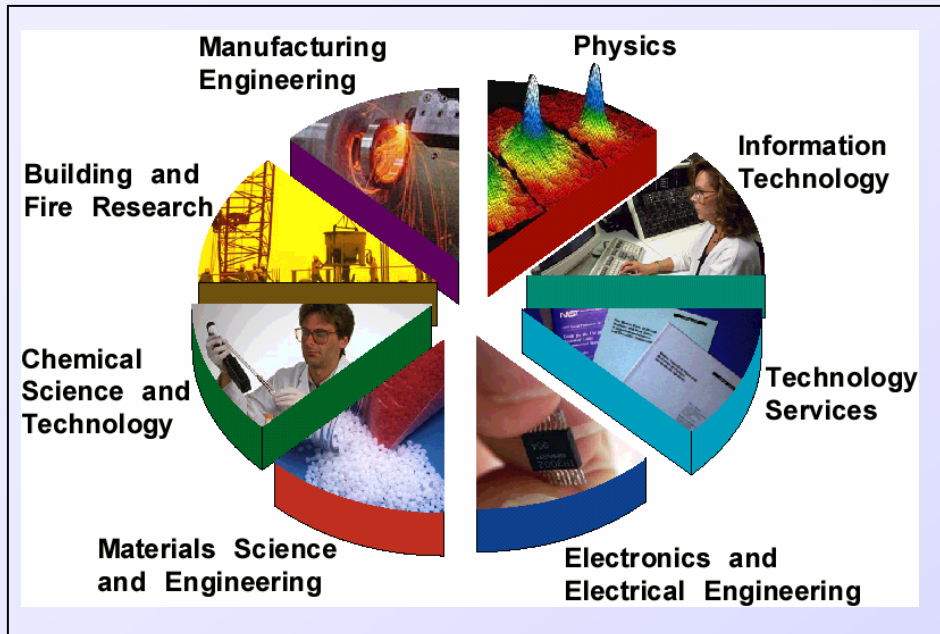


- Premier U.S. award for performance excellence and quality achievement.
- Awards in Manufacturing, Service, Small Business, Education, Health Care.
- More than 2 million copies of Criteria for Performance Excellence distributed (not including downloads from Web).

www.baldrige.nist.gov



NIST Laboratories and Technical Staff



Multidisciplinary expertise to develop measurements and standards to enable:

- ☐ **Science**
- ☐ **Technology innovation**
- ☐ **Trade**
- ☐ **Public benefit**

NIST plans and works in close collaboration with customers:

- ☐ **Industry**
- ☐ **Other agencies**
- ☐ **State and local governments**
- ☐ **Measurement laboratories**
- ☐ **Standards development organizations**

Unique Measurement and Research Facilities

AML

Advanced Measurement Laboratory :

- Unparalleled environmental control
- Nanofabrication Facility
- Completion targeted for 2004

Advanced Chemical Sciences Laboratory

- Critical capabilities in nanobiotechnology and analytical chemistry

ACSL

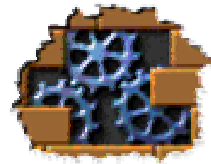
NIST Center for Neutron Research

- Most versatile neutron facility in the US with over 1750 users annually

NCNR

<http://www.memsalliance.org>

MEMS Alliance



An alliance of companies, universities, and government laboratories in the Washington DC metropolitan area. Our mission is to create a group that networks expertise, capabilities, and research to facilitate the development of new applications and commercialization of miniaturization technologies.

www.memsalliance.org

Maryland
Washington DC
Virginia

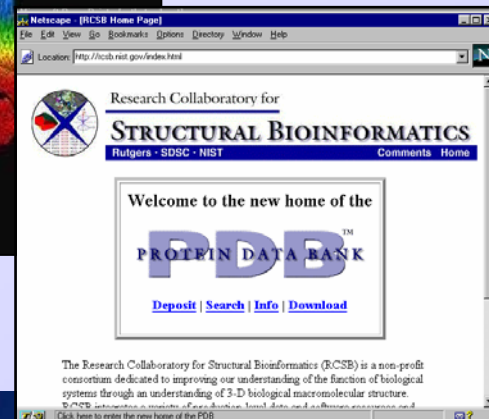
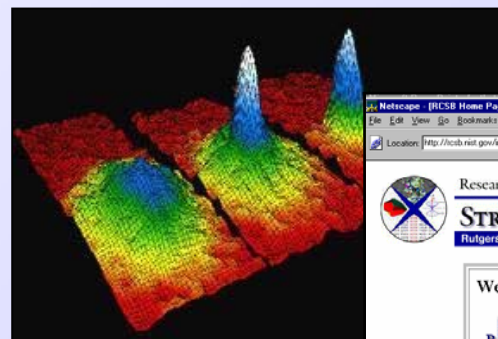
MEMS
Microfluidics
BioChips
Microfabrication
Microsystems
Cell Phone on a Chip

An Alliance Of
Companies
Universities
Government Laboratories

MANA – Mid-Atlantic Nanotechnology Alliance

NIST Products and Services

- **Measurement Research**
2,200 publications/year
- **Standard Reference Data**
90 types available
5,500 units sold/ year
- **Standard Reference Materials**
1,300 products available
31,000 units sold/year
- **Calibrations and Tests**
3,000 items calibrated/year
- **Laboratory Accreditation**
819 accreditations
- **Standards Committees**
440 NIST staff, 970 committees



Strategic Focus Areas

NIST 2010

- ☐ Health Care
- ☐ Nanotechnology
- ☐ Homeland Security
- ☐ Information / Knowledge Management



MEMS and Nanotechnology Overview

- **Standardization**
 - Measurement Methods
 - e-Standards
 - Manufacturing
- **Devices for improved measurements**
 - NanoBioTechnology
 - Single molecule measurements

Standardization Groups

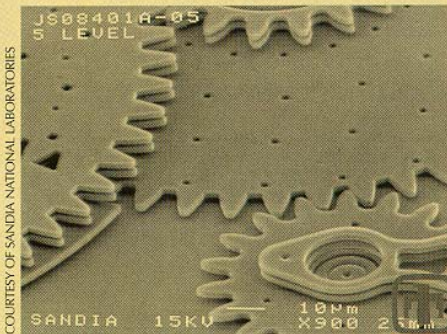
Task Group Descends On Micro-Technology

An ASTM task group is working with tiny mechanical parts smaller than the width of a human hair. Work on microelectromechanical systems (MEMS) standardization is under way in Task Group E08.05.03 on Structural Films and Electronic Materials, under Subcommittee E08.05 on Cyclic Deformation and Fatigue Crack Formation, in Committee E-8 on Fatigue and Fracture. Scientists experienced in fatigue and fracture and/or creep-process are sought for development of MEMS test methods.

In these tiny systems, barely visible gears, hinges, motors, and other mechanical components are manipulated by micro-tweezers and probes, and viewed with scanning electron microscopes. "Imagine everything in day-to-day life being miniaturized: gears, wheels, motors, turbine engines, everything. My whole fatigue testing machine fits on a silicon chip a few hundred microns square," said Task Group Chairman Chris Muhlstein, a materials scientist in the Materials Science and Engineering Department, University of California, Berkeley.

MEMS are made from combinations of metals, ceramics, and polymers. "The little nozzles on your ink-jet cartridge are probably one of the

(CONTINUED ON NEXT PAGE)



Smaller than the width of a human hair, microscopic gears of this type are used in polysilicon microengine transmissions, an important application for new ASTM standards.

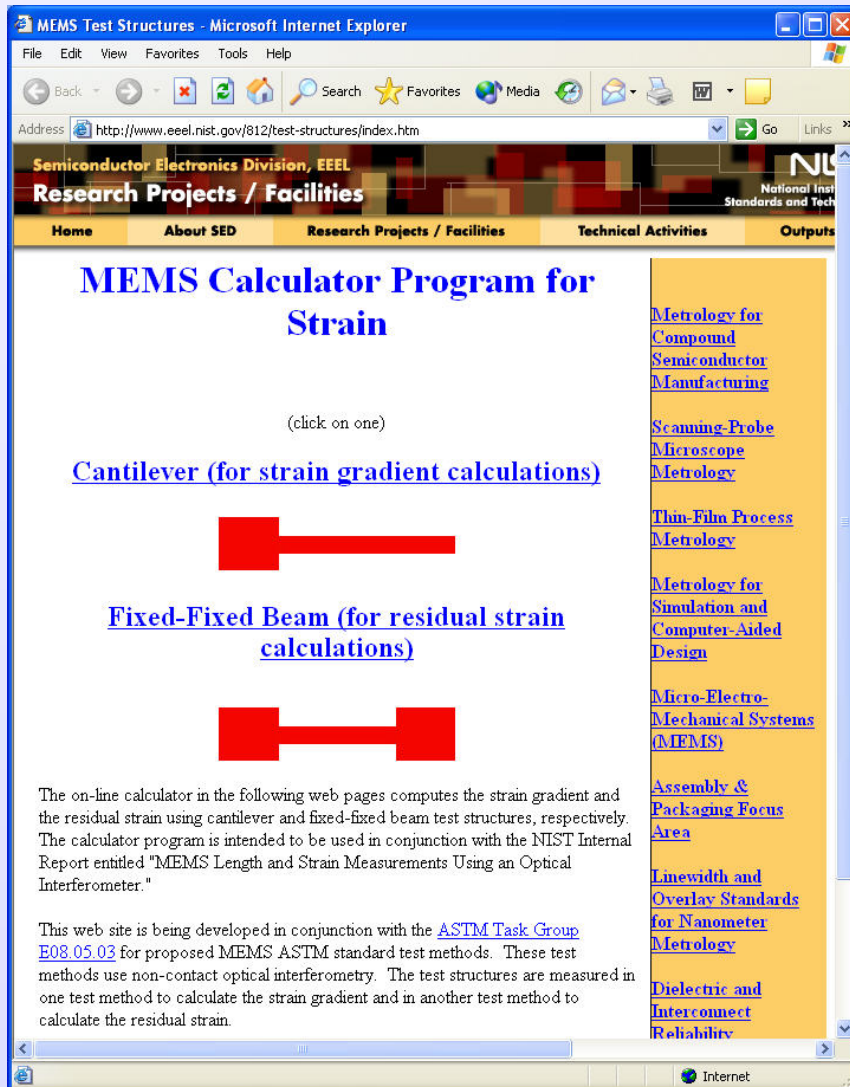
- **ASTM**
Task Group E08.05.03
Est. 1998
Measurement Methods - Residual Stress, Elastic Modulus
- **Micromachine Standardization Forum**
Japan's MMC
Est. 2000
Terminology
- **SEMI**
IMSG - International MEMS Standardization Working Group
Est. 2003
Manufacturing

Dimensional Measurements of MEMS Test Structures



- NIST Report on measurement of length and strain measurements.
- 3 ASTM Test methods for dimensional and strain measurement are completed.
- A round robin experiment to determine precision and bias is in progress.

e-Standards

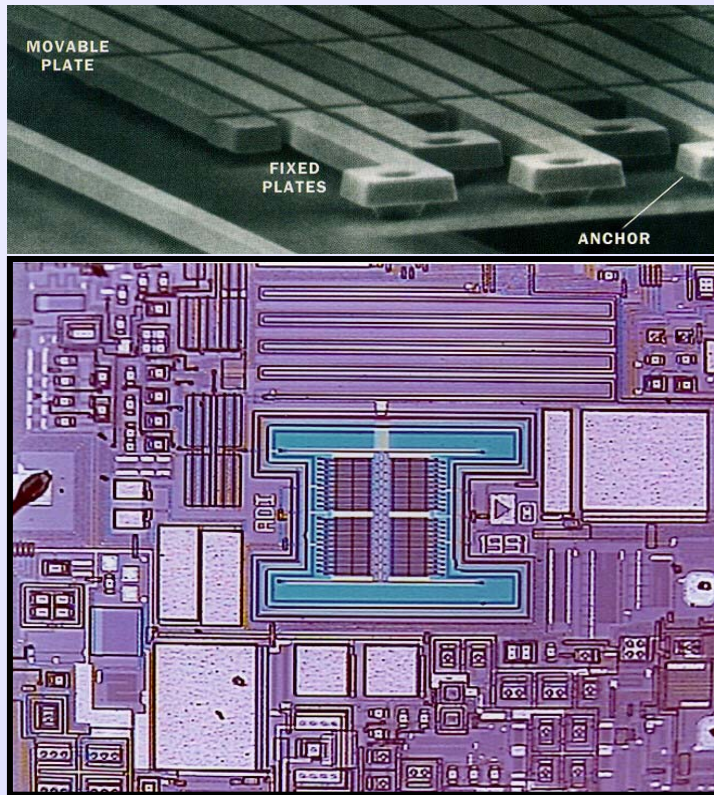


On-line hyperlink documents that:

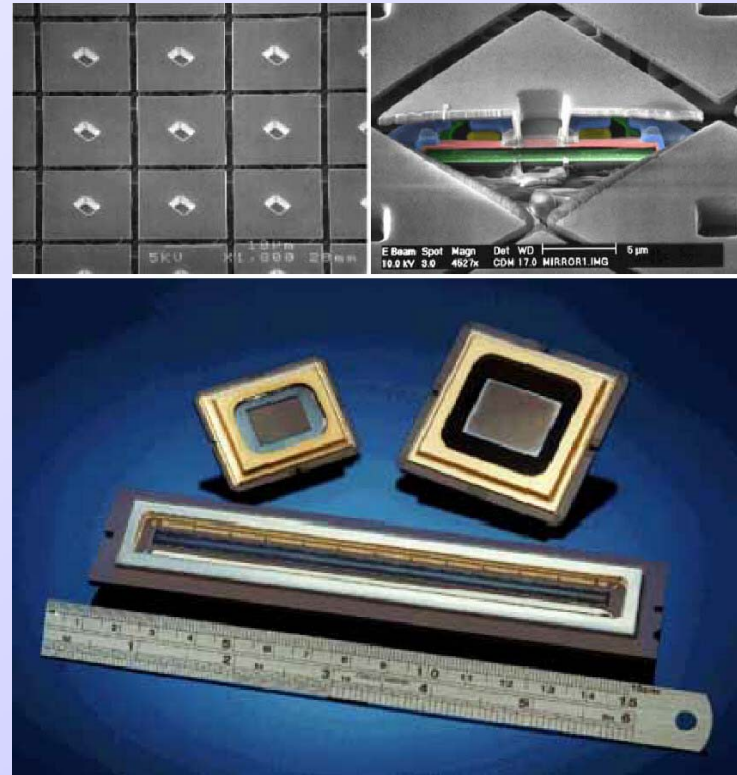
- Provide a guide through the measurement procedure.
- Currently: cantilevers and buckled beams.
- Will provide links for explanations to questions the user might have.
- Will include other information such as web links to other standards, references, and people to contact.

Systems

Commercial Examples

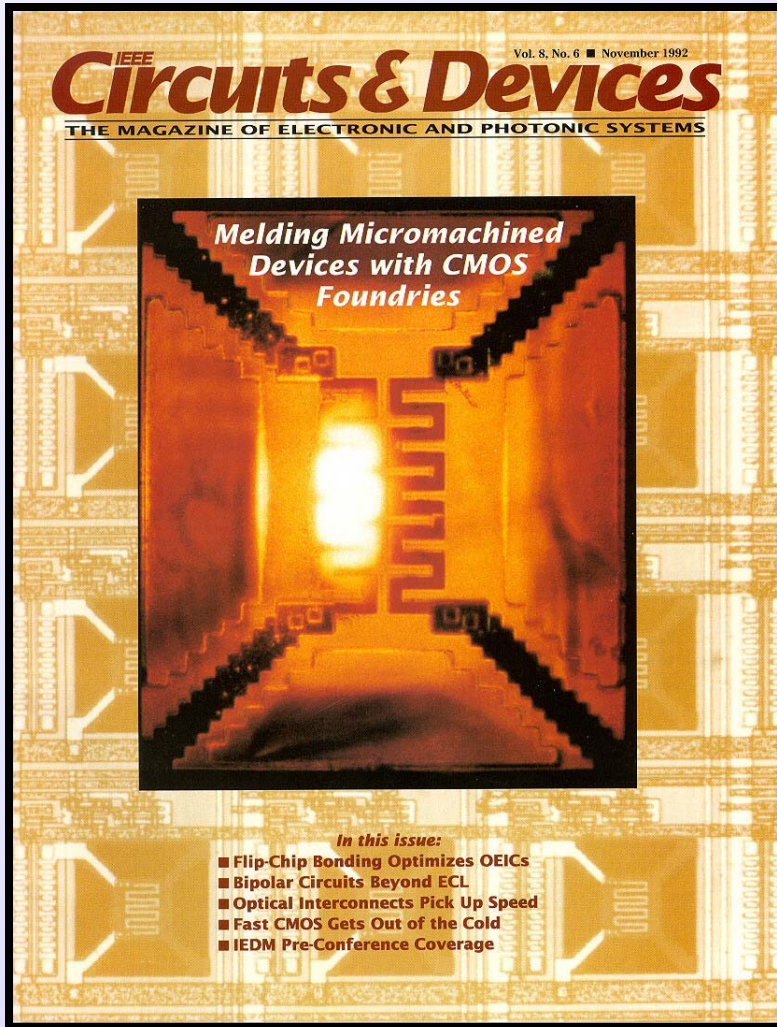


Analog Devices
Accelerometer



Texas Instruments
Deformable Mirror Display

Manufacturing



CMOS-Integrated Circuit-Foundry MEMS – *cif*-MEMS

Circuits and Devices:
“Melding Micromachined
Devices with CMOS
Foundries,” November
1992

<http://www.mosis.org/Products/mems.html>

cif-MEMS

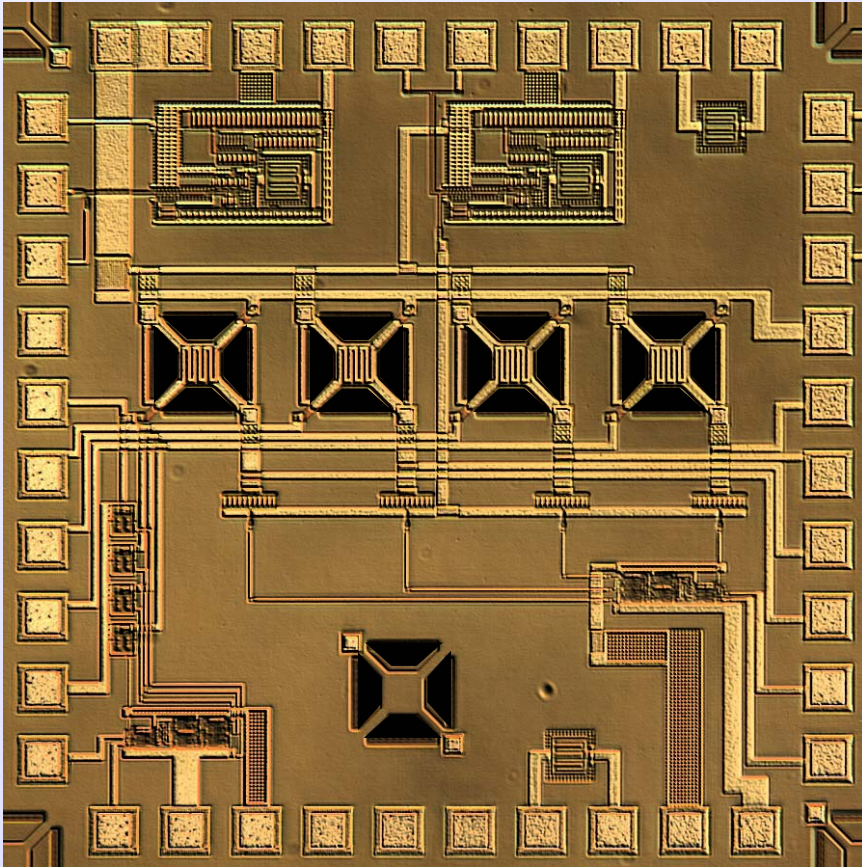
- Devices
 - Thermal-Based Elements

Thermal Displays, Microhotplate Gas Sensors, Convective Accelerometers, Flow Sensors, Vacuum Sensors, Microchemical Reactors
 - Microwave Elements

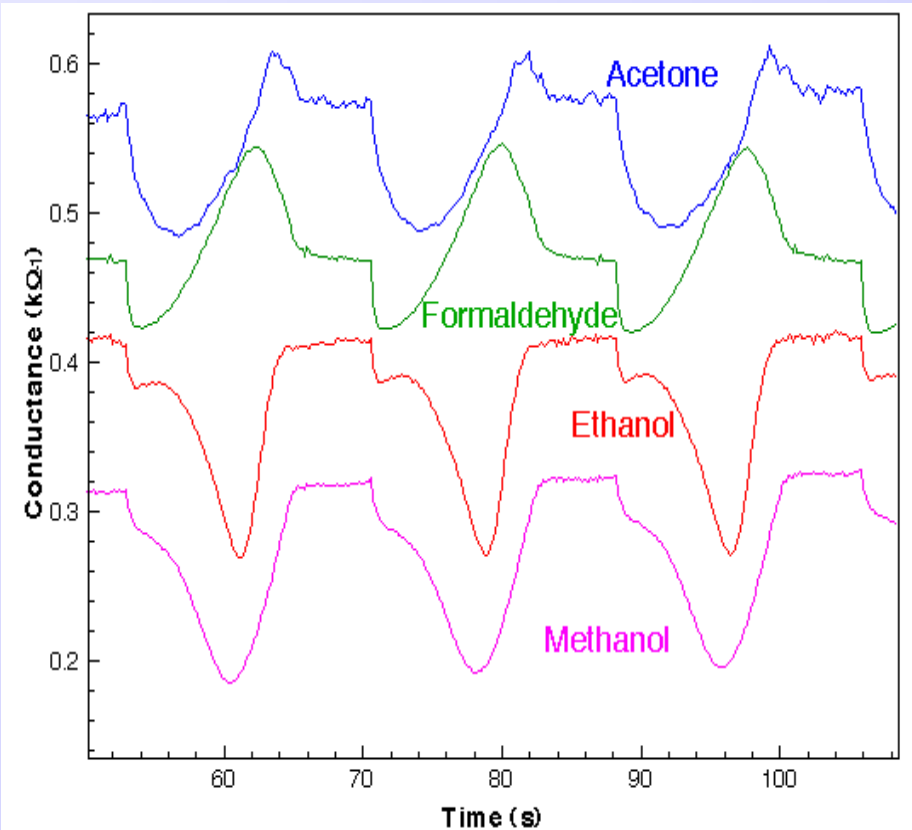
Spiral Inductors, Coplanar Transmission Lines, Antennas, Resonant Filters, Power Sensors
 - Electromechanical Elements

Resonators, Accelerometers, Micro mirrors

Microhotplate Gas Sensors

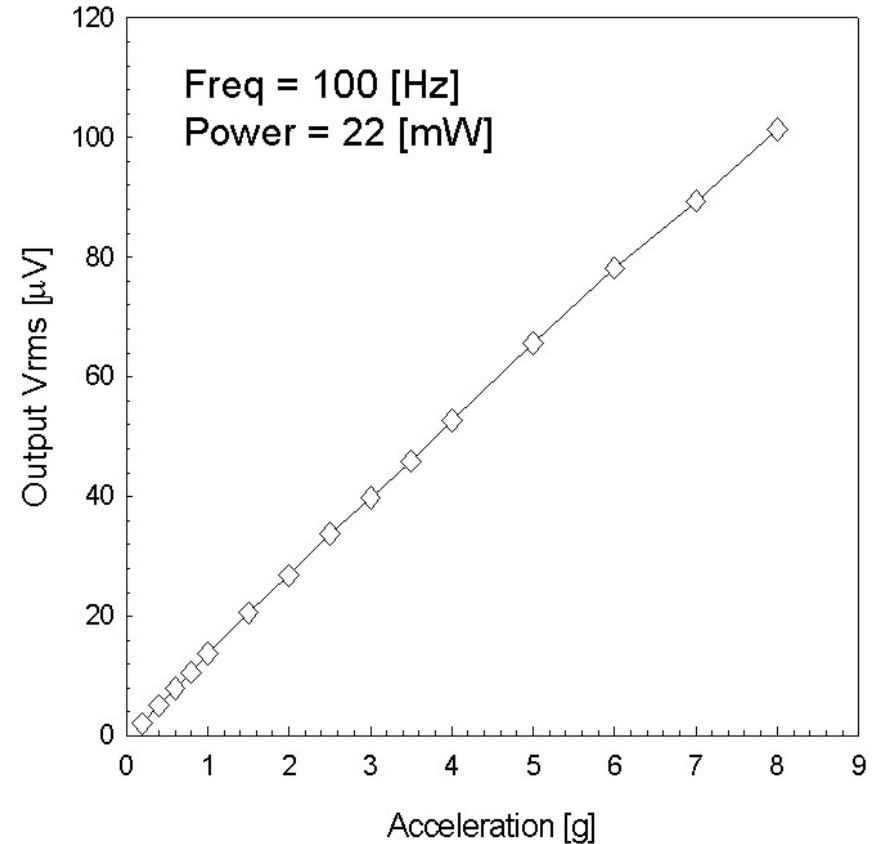
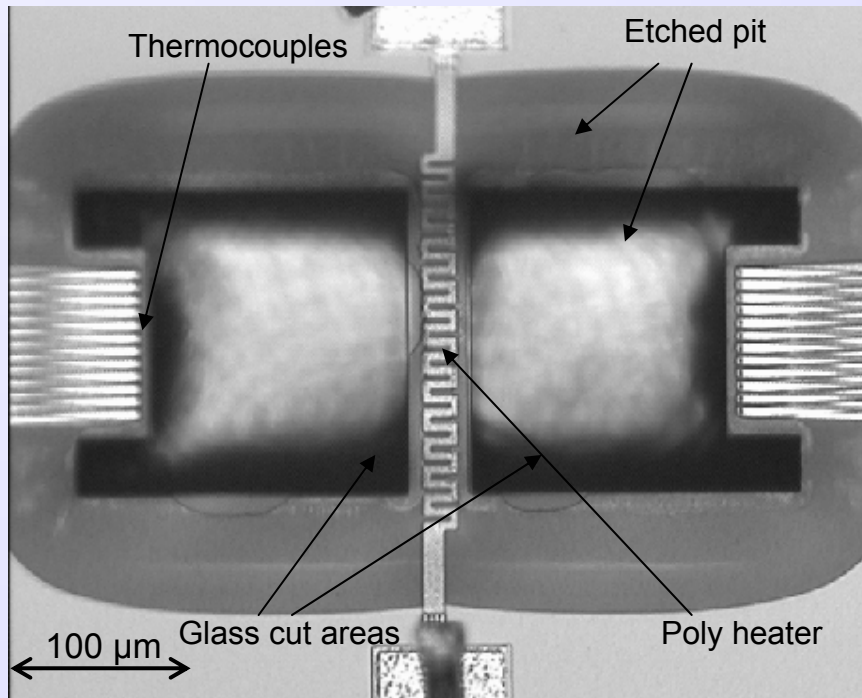


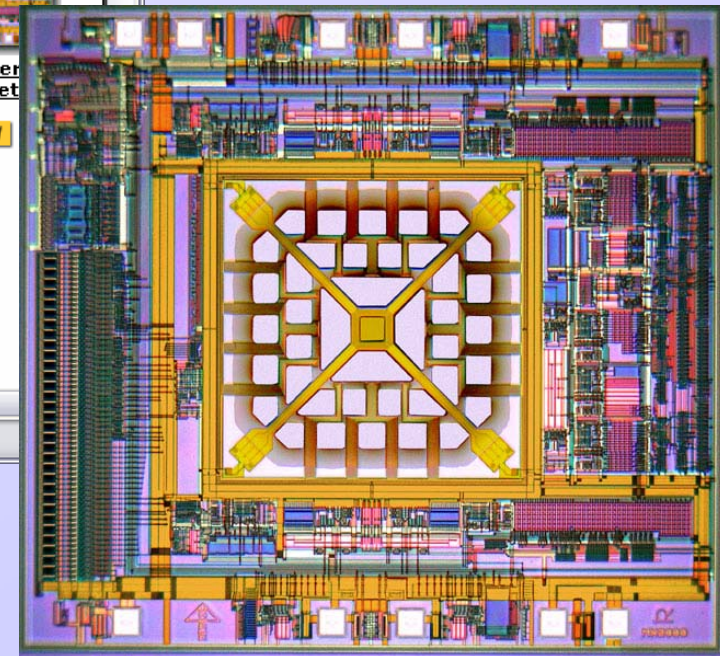
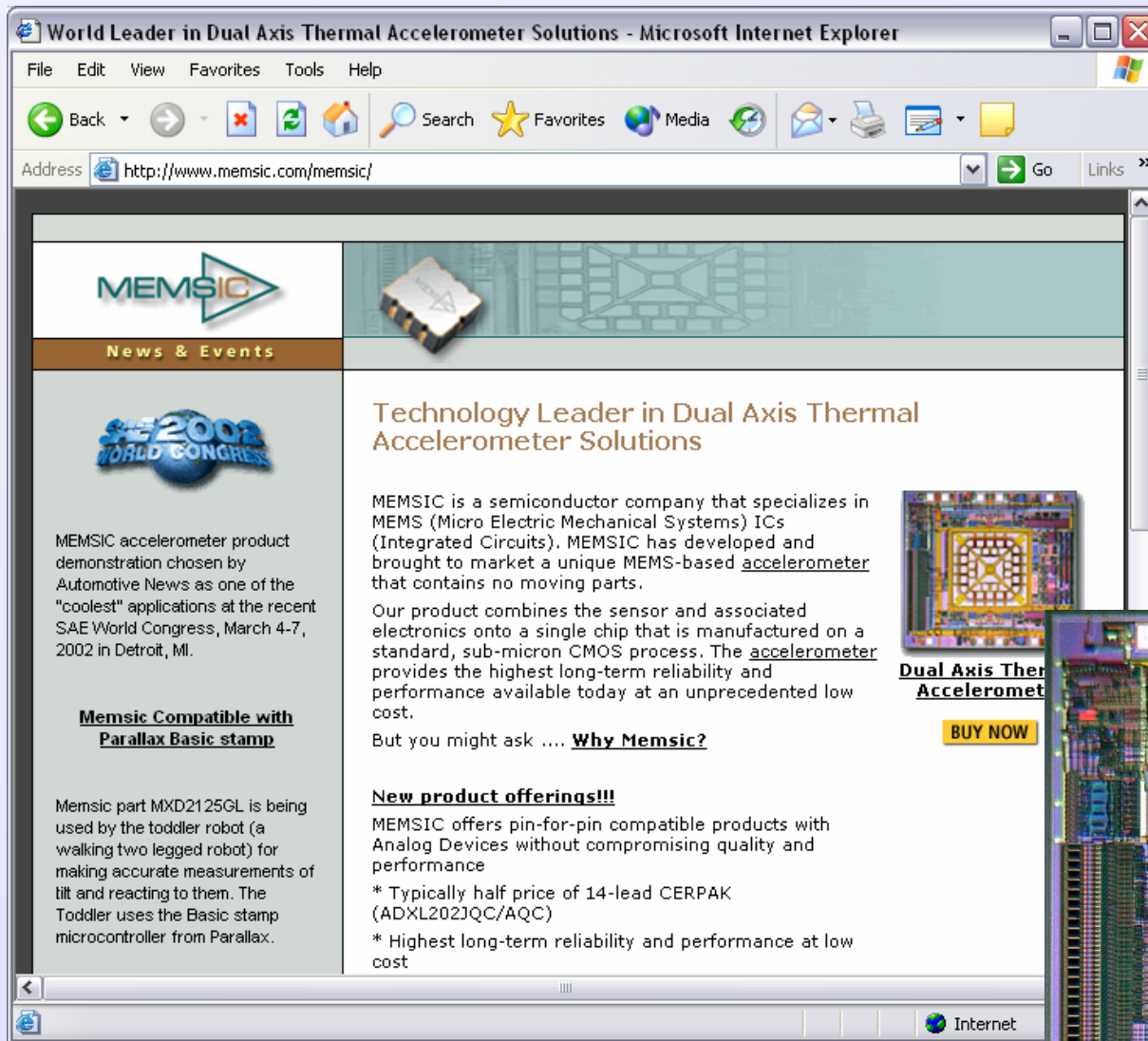
Semiconductor Electronics Division EEEL



Process Measurements Division CSTL

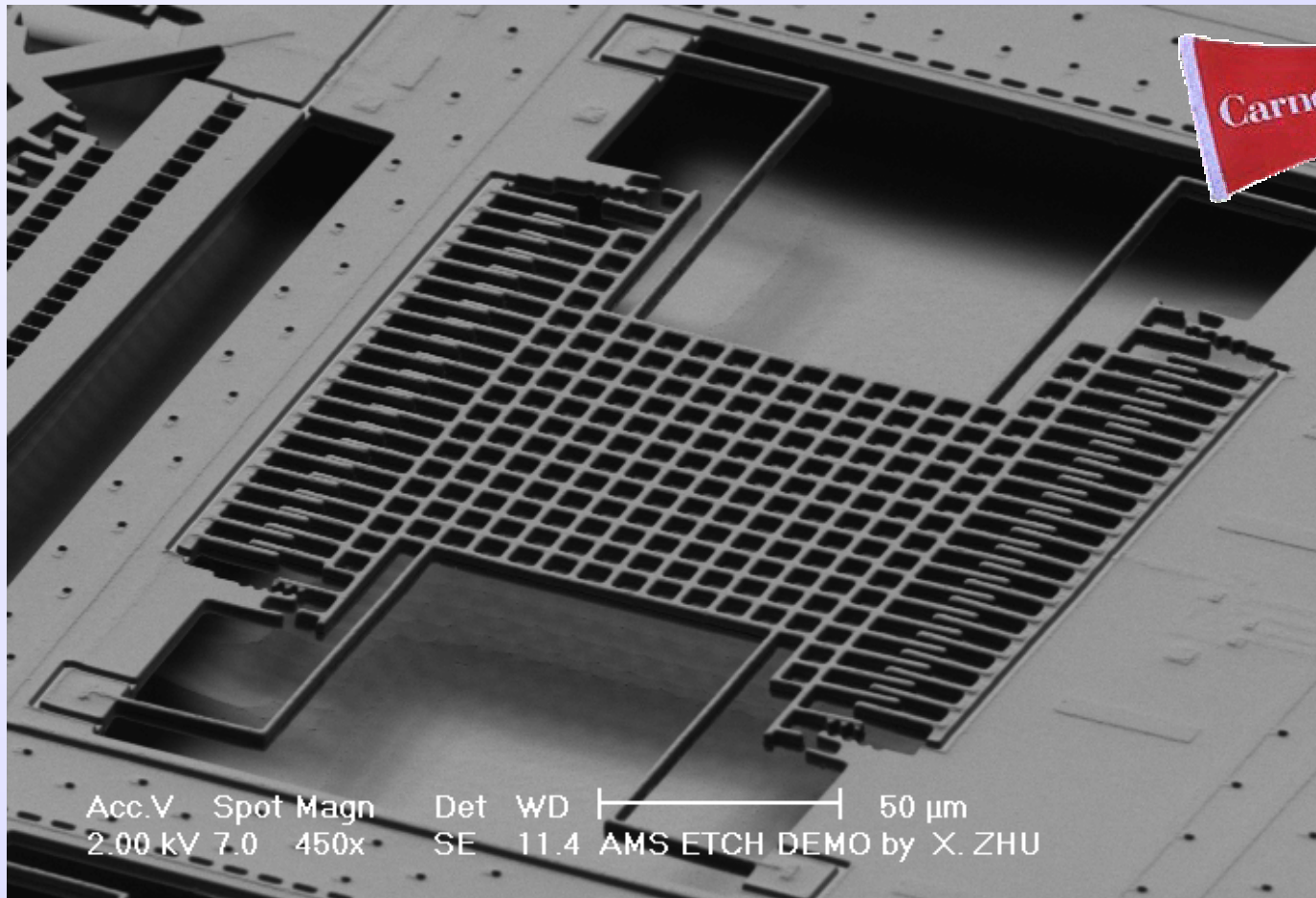
Convective Accelerometer





<http://www.memsic.com>

ASIMPS Post-CMOS Micromachining

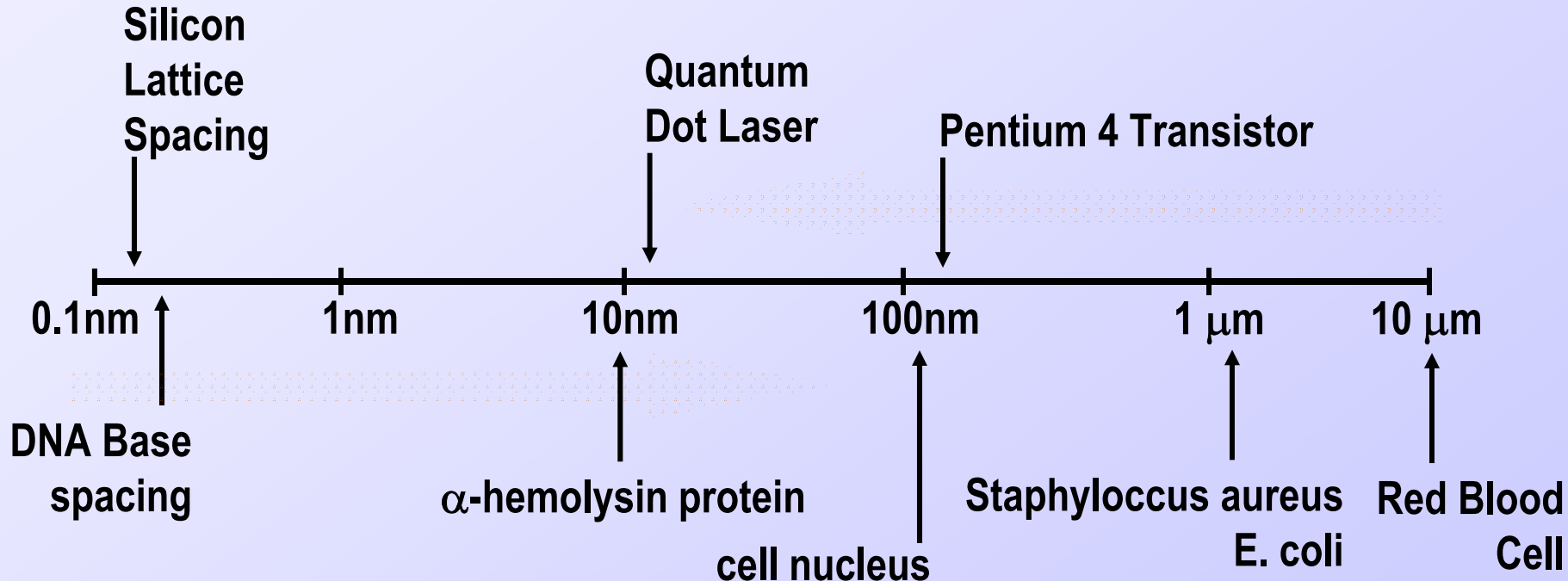


ASIMPS: AMS 0.6 μm , 3-metal

<http://www.ece.cmu.edu/~mems/projects/asimps>

Scales

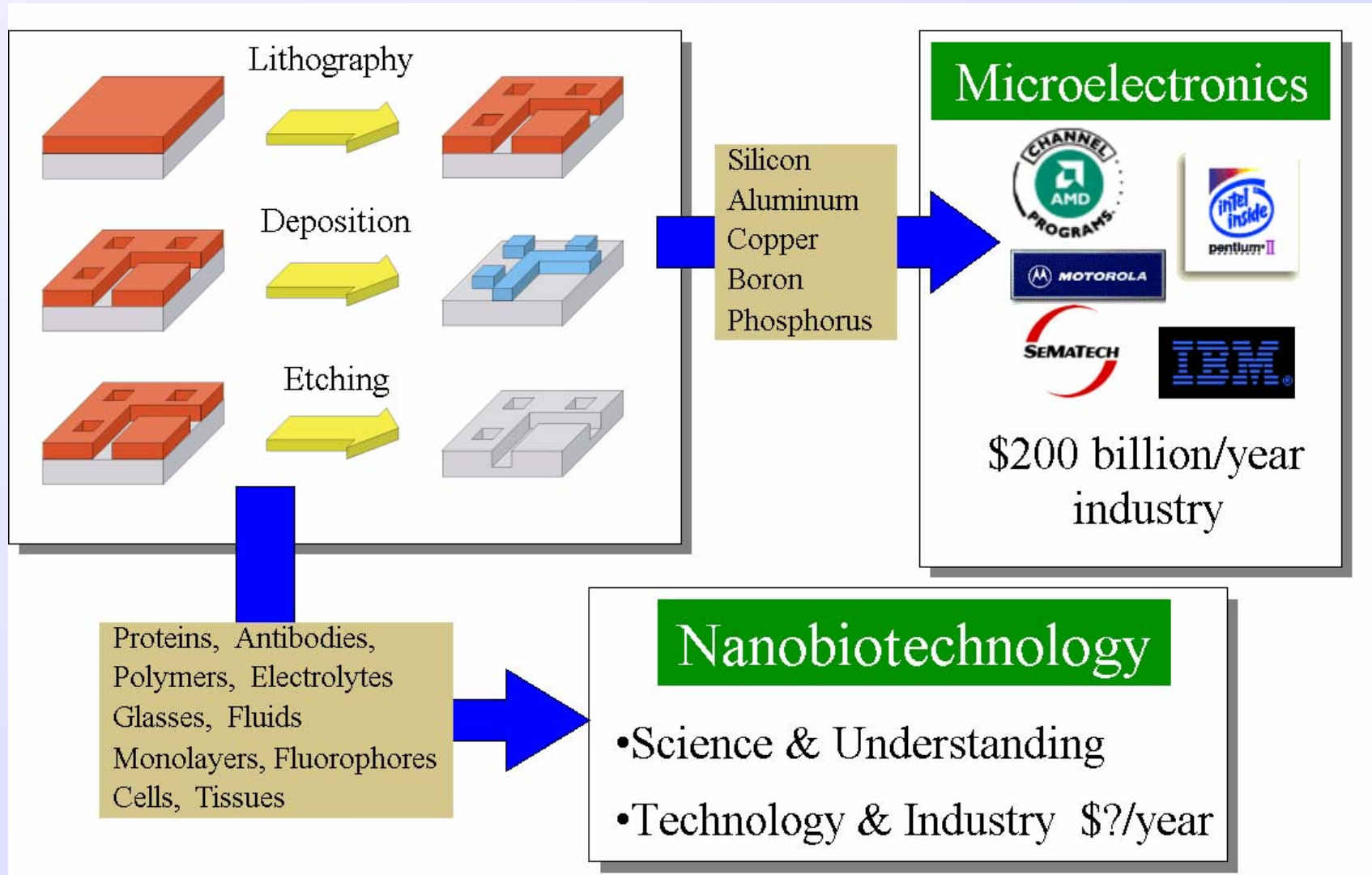
Electronics: Top-Down



Biotechnology: Bottom-Up

Human DNA
3 billion base pairs
1 meter total length

Nanobiotechnology = Nanofabrication + Biotechnology



Single Molecule Manipulation and Measurement: SM³



Gaithersburg



Information Technology
Laboratory
Physics Laboratory

Boulder



CARB



JILA



Michael Gaitan

MEMS Project
<http://mems.nist.gov>

September 9, 2003
NSA Visit



CSTL



John Kasianowicz, Biophysicist
Protein Nanopores

PL



Lori Goldner, Physicist
Nano-Optics

EEEL

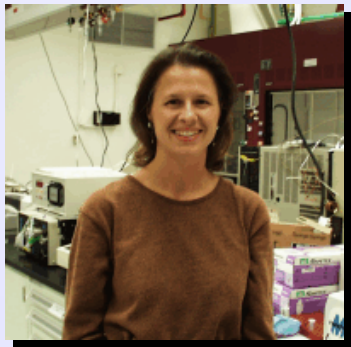


Michael Gaitan, Electrical Engineer
MEMS and Nanofabrication

ITL



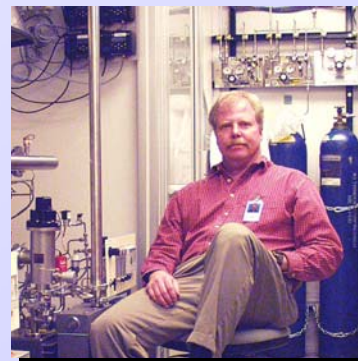
Vince Stanford, Mathematician
Signal Analysis



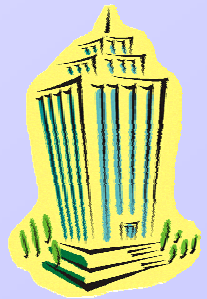
Laurie Locascio, Biomedical Engineer
Microfluidic Systems



Angela Hight Walker, Chemical Physicist
Molecular Spectroscopy



John Moreland, Physicist
Nano-Magnetics and MEMS



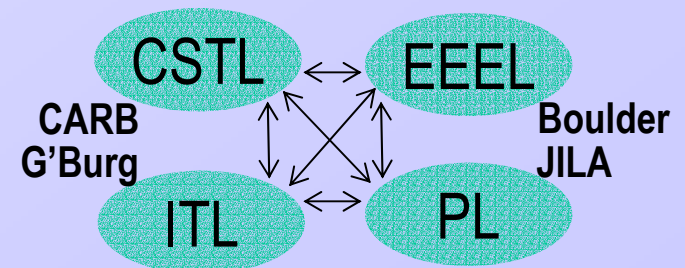
NIH



John Marino, Biochemist
NMR Proteins



David Nesbitt, Chemical Physicist
Single Biomolecule Fluorescence



SM³ Program Objective

*To develop and integrate new measurement methods to transport and probe structure, function, and dynamics of **single biomolecules***

DNA, RNA, and Proteins

NIST Role

Measurements and Standards

Industry trend is
smaller sample size

- genomics
- proteomics
- microfluidic systems
- lab-on-a-chip
- chem/bio sensors



Gene Chip

SM3 Deliverables

Measurement

- methods
- platform
- protocols
- standards
- data



\$1B Proposed for DNA Testing
Washington Post, March 12, 2003

Measurement Challenge

Complete structural and functional measurements on single molecules.

How to isolate them?

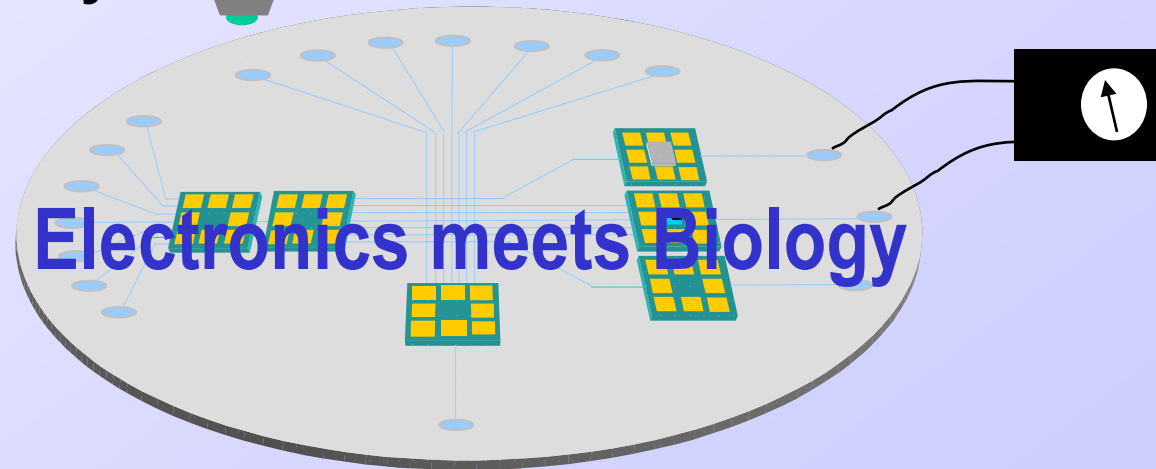
How to measure them?

Technical Approach

NanoBioTechnology Platform

Platform based on
Nanofabrication
Molecular Assembly

Manipulation (Transport):
Fluidic Restrictions,
Beads

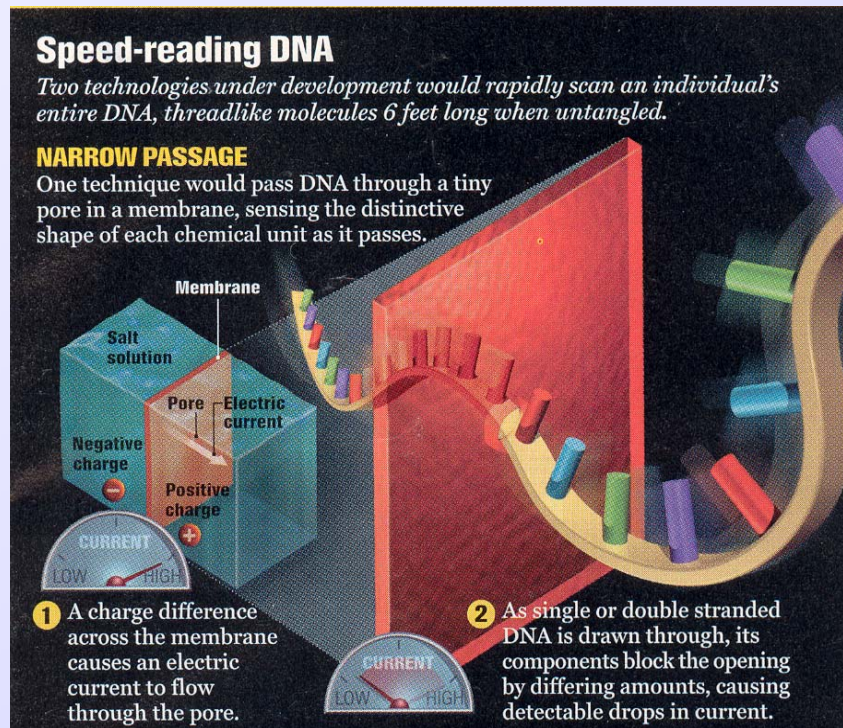


Measurements:
Electronic, Optical, Force

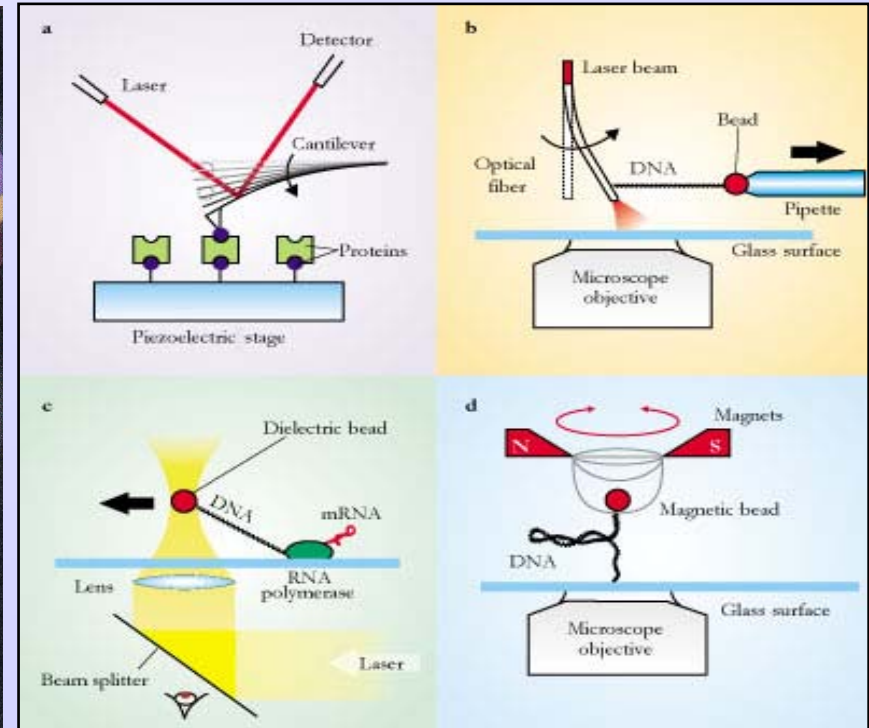
Manipulation (Capture):
Vials, Beads, Arrays

Manipulation and Measurement

Electronic ... Optical ... Mechanical

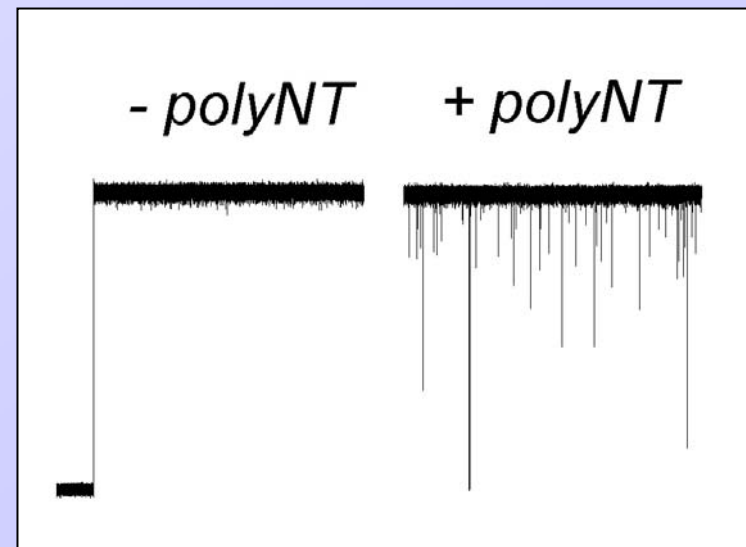
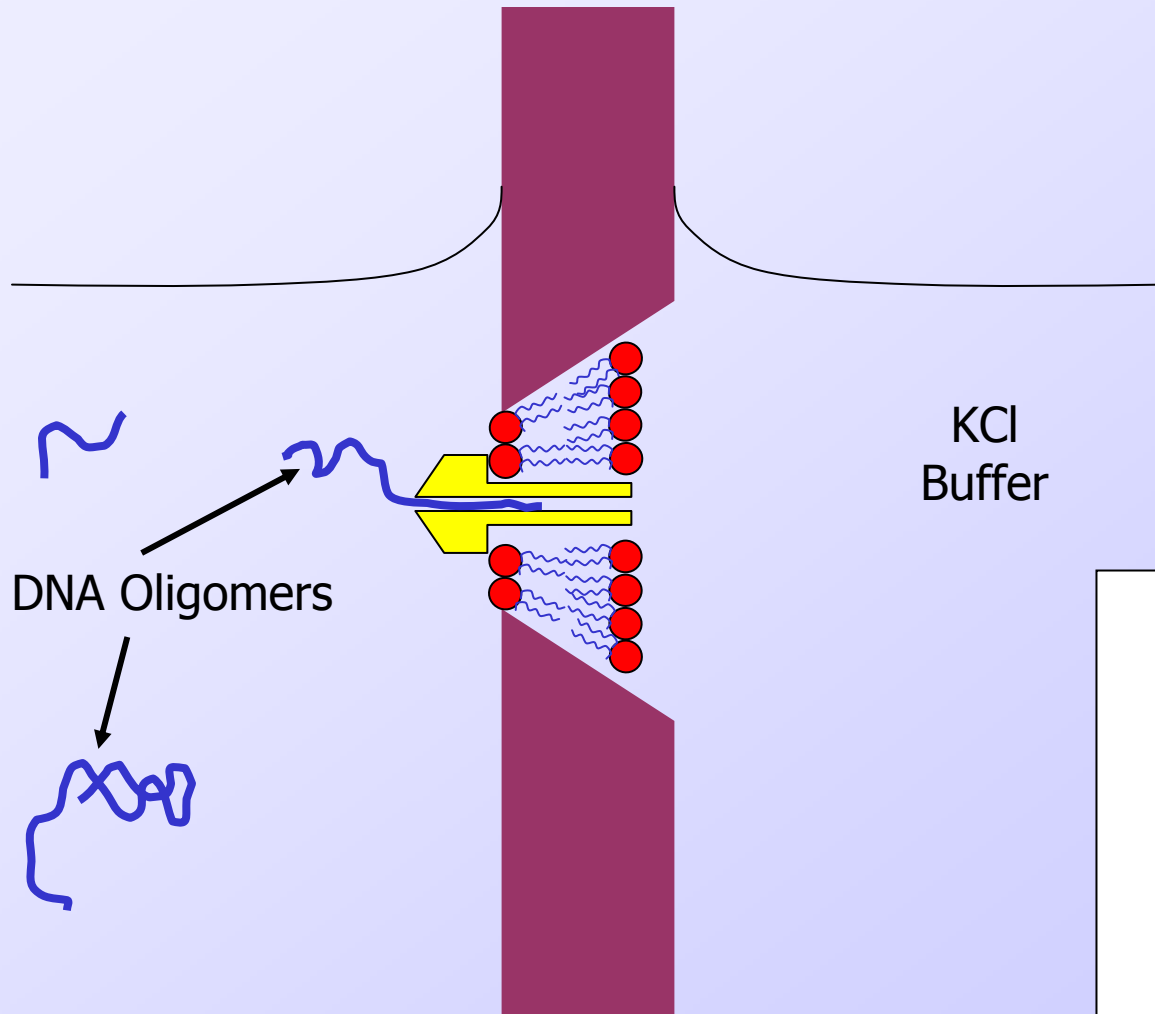


US News and World Report, May 2002



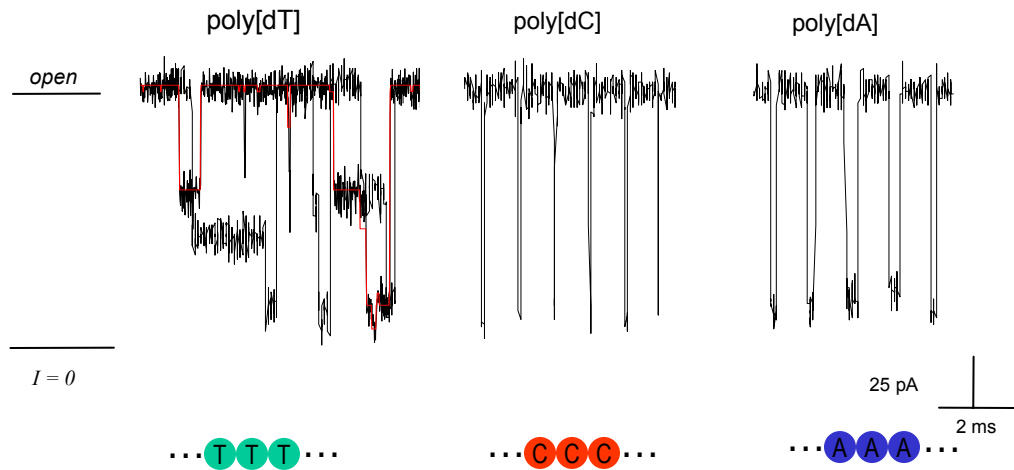
Physics Today, October 2001

Protein Nanopores

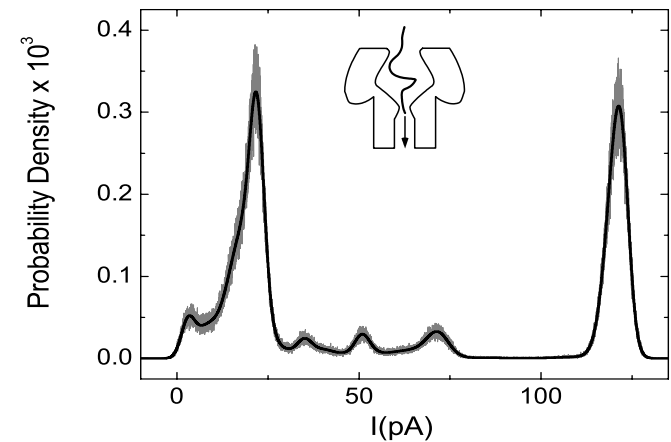
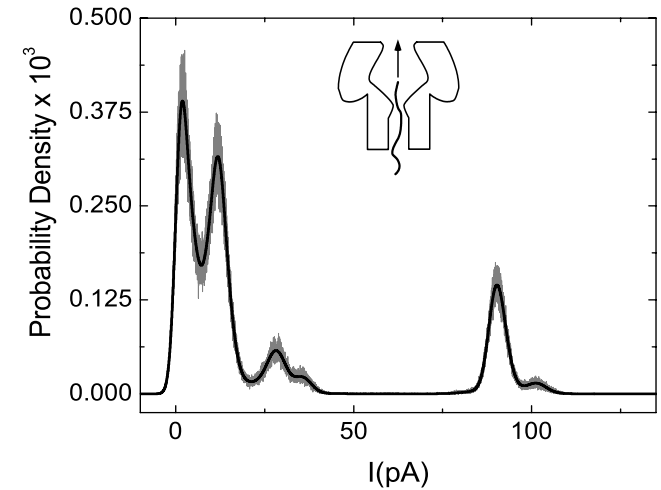


Data Analysis

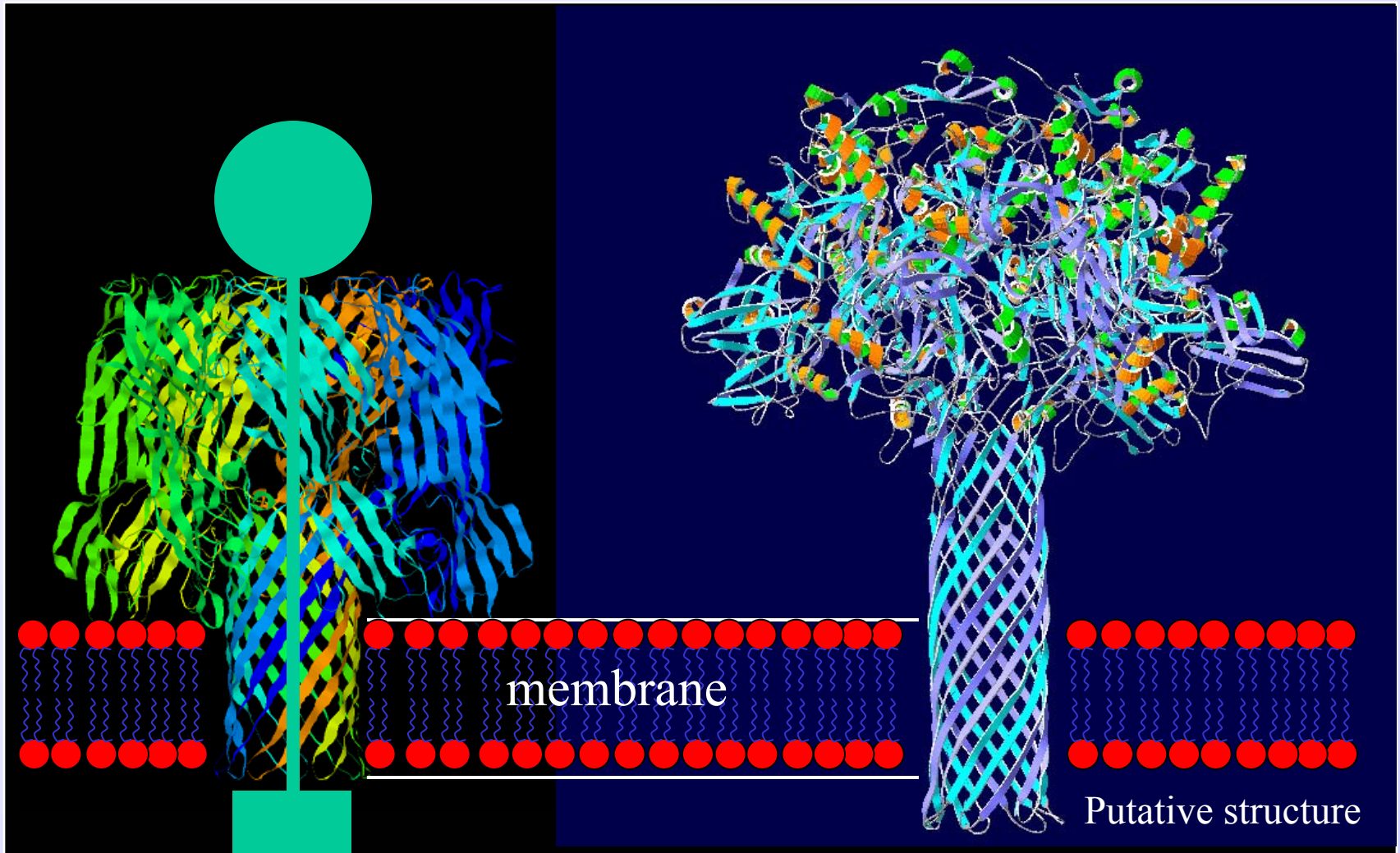
Decoding Algorithms



- Identical length DNA molecules cause different signals
- Signal content depends on the transport direction
- Building computer systems & software to decode information in molecules



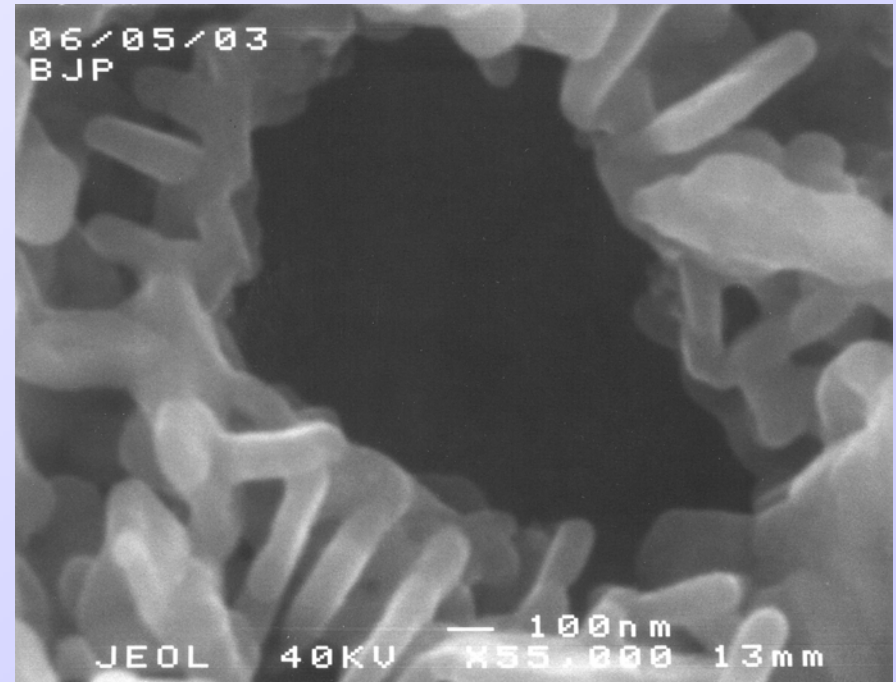
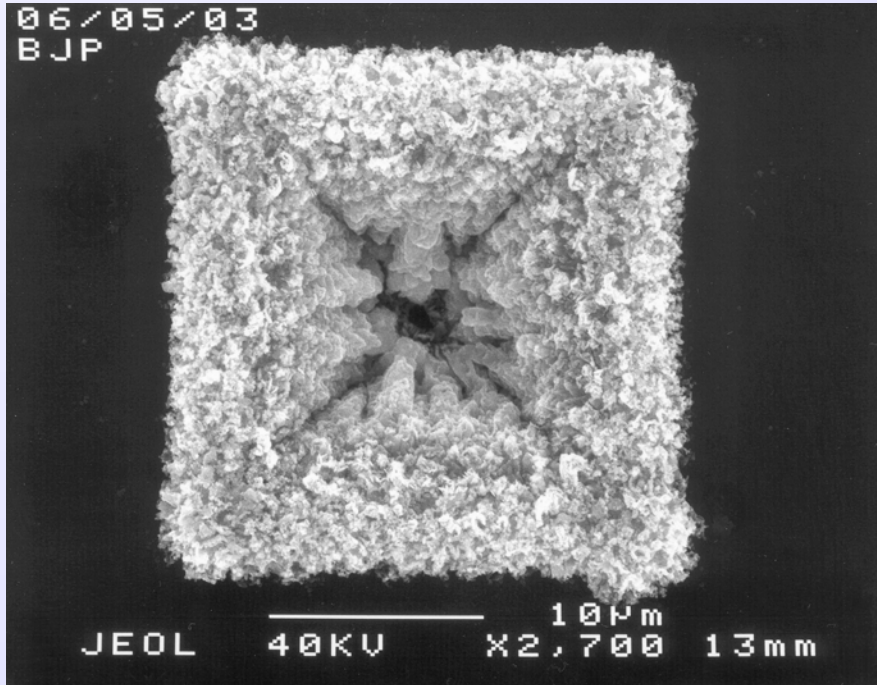
Protein Nanopores



S. aureus α HL

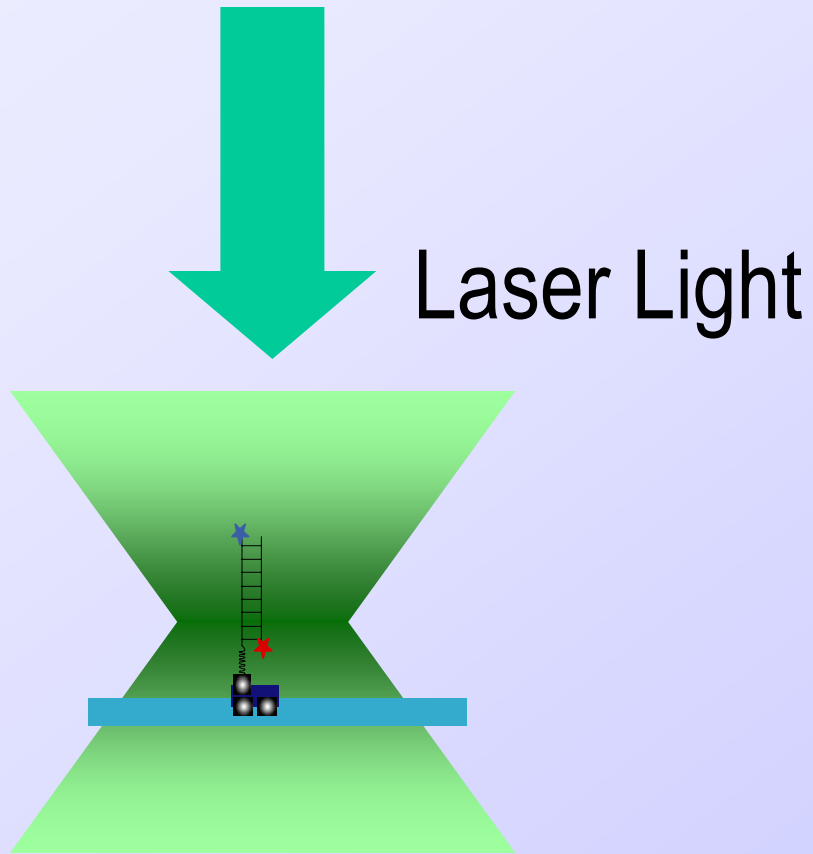
B. anthracis PA₆₃

Solid State Nanopores

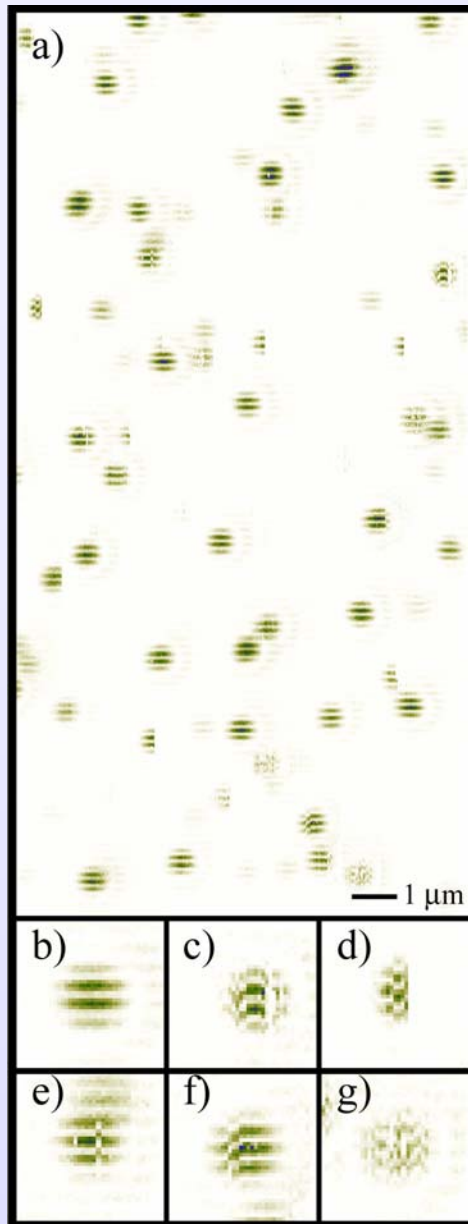


Electroplated

Single Molecule Optical Measurements

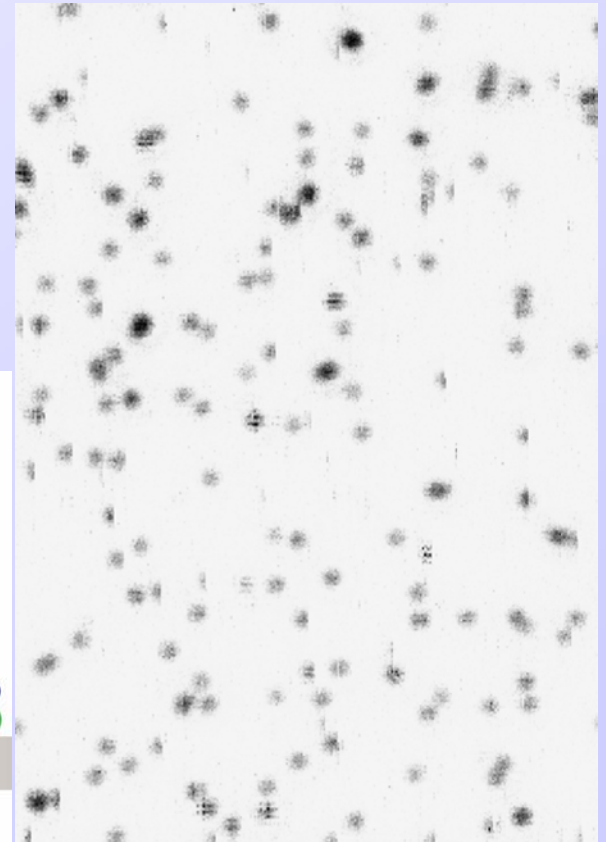
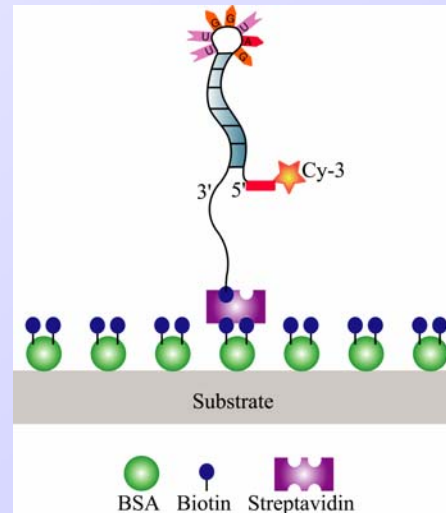


Activity of surface attached biomolecules

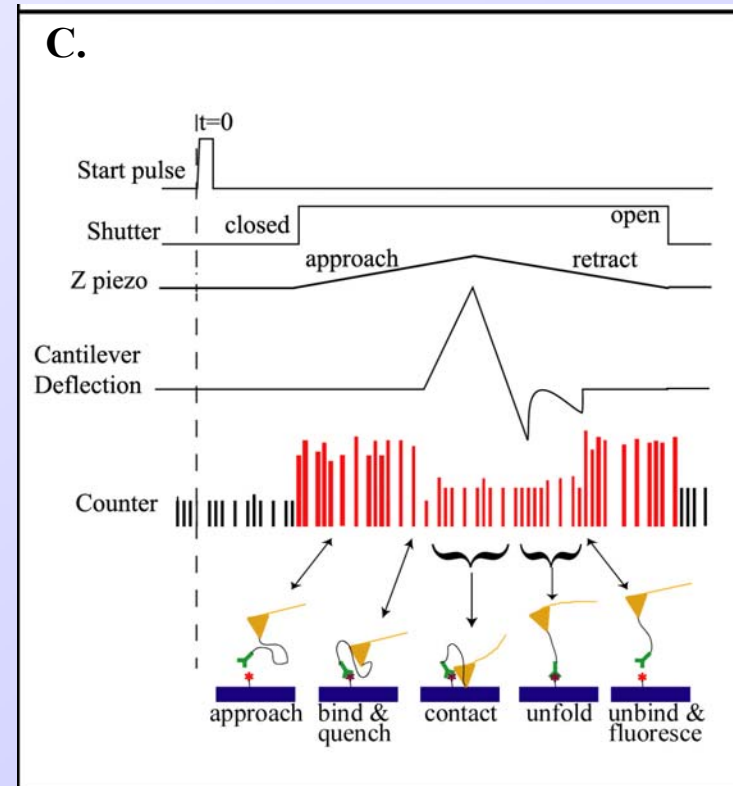
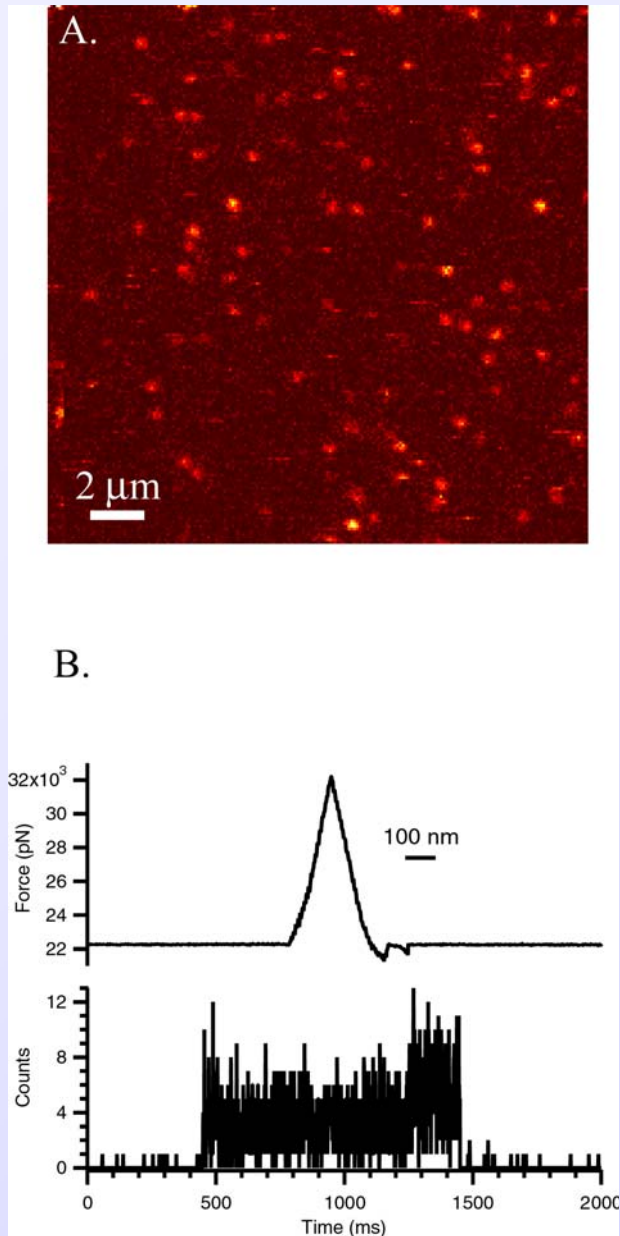


Dye molecules
in polystyrene

RNA on biotinylated
glass



Simultaneous force and optical measurements: antibody/antigen interactions



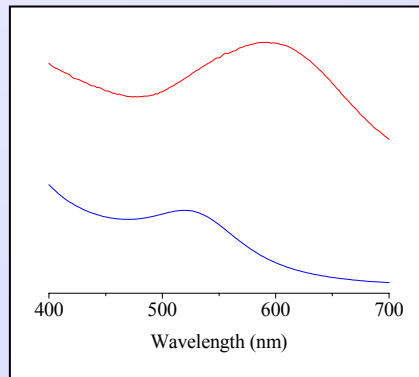
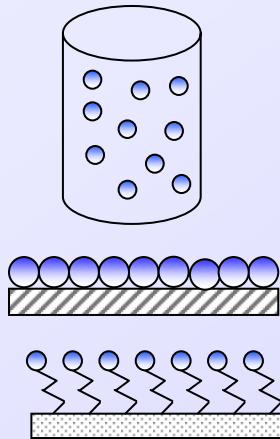
Example: Alexa fluor 488 attached to glass.
Anti-alex a attached to AFM tip. Anti-alex a
quenches the fluorophore.

Single Molecule Vibrational Spectroscopy

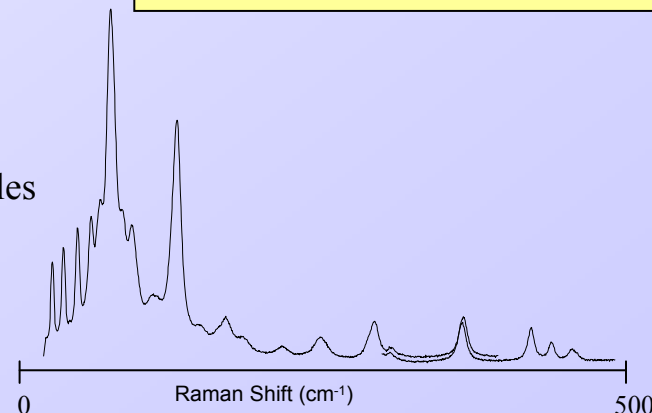
Surface Enhanced Raman Scattering (SERS)

Enhancement of Raman cross section can be as large as 10^{15} thereby permitting single molecule detection, however, nanostructure morphology, concentration, material, etc. are all critical to obtaining reproducible SERS substrates.

Goal: Quantitative SERS



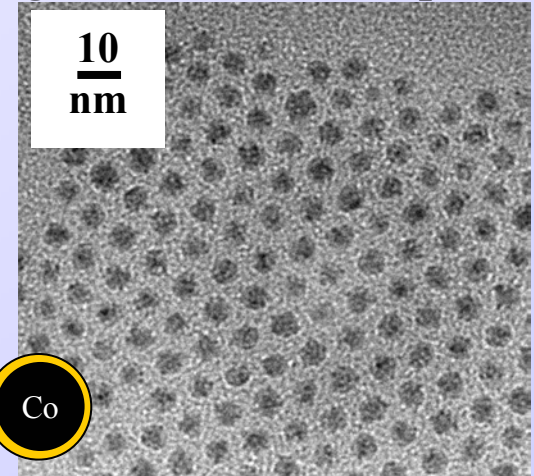
UV-VIS of 5 nm Au nanoparticles



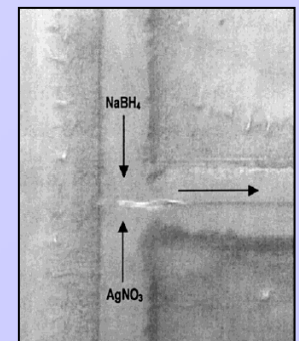
Vibrational Spectroscopy *in situ* in a MEMS device

Concentrate on low frequency vibrational modes--**detailed structural info!!**

Magnetic Cobalt Nanoparticles

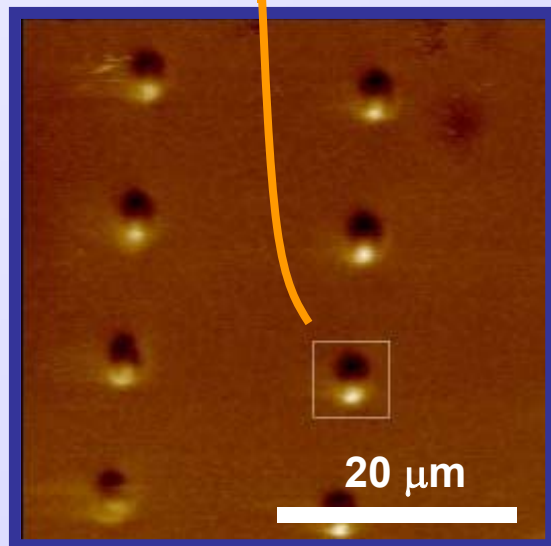
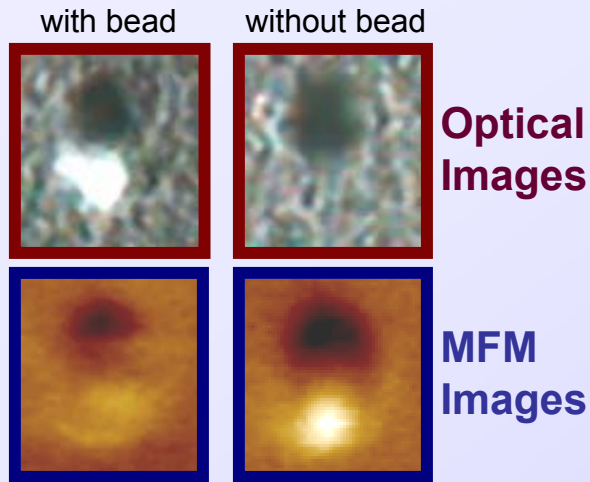


Need gold-coated Co nanoparticles for SM sensitivity **and** magnetic manipulation

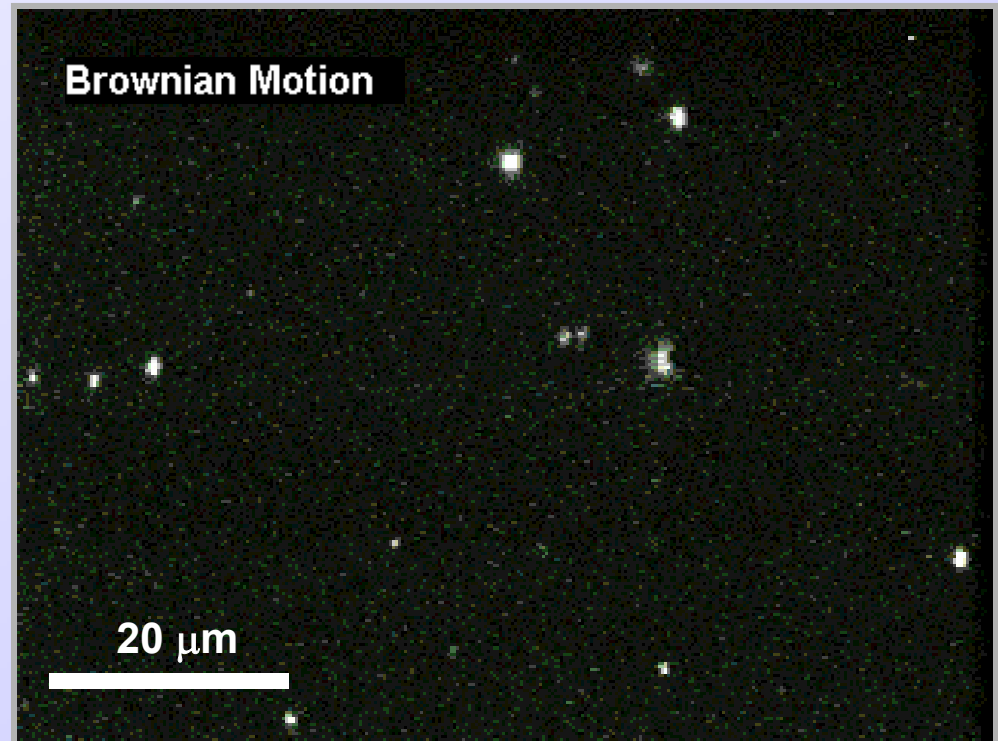


E. Smith, Glasgow

Magnetic bead trapping and position control

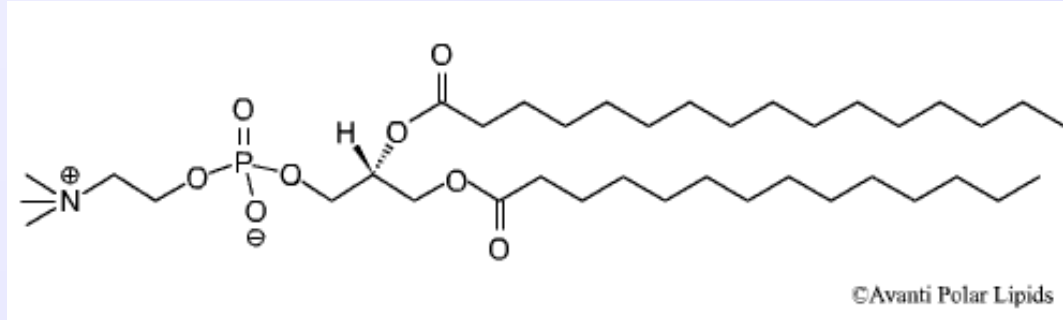


Trapping magnetic beads



Fluorescence microscopy video of magnetic beads coated with FITC dye near NiFe magnetic traps with and without applied field ($H_{\text{bias}} = 1 \text{ kOe}$).

Nanovials - Liposomes



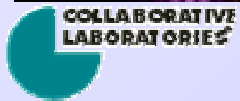
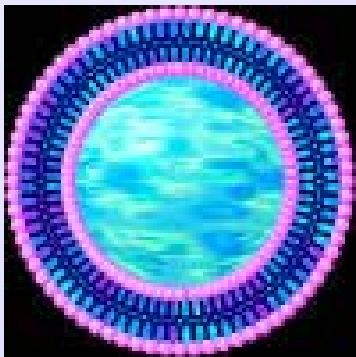
DLPC (C₁₂)

DMPC (C₁₄)

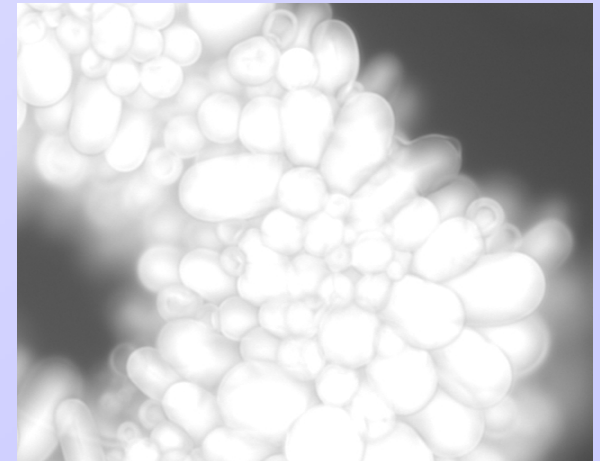
DPPC (C₁₆)



Disperse in water and
vesicle formation is
spontaneous



Spherical vesicle

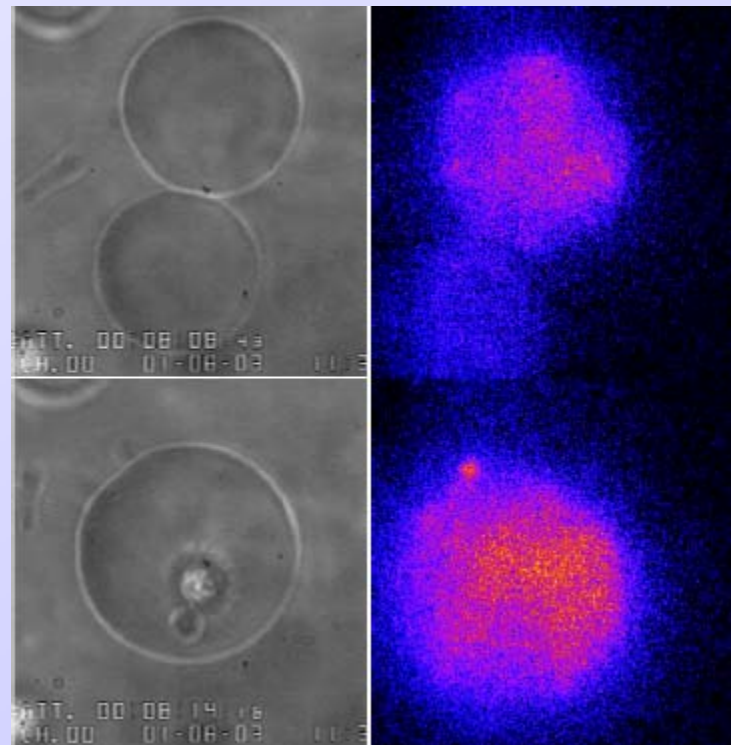


Liposomes

Nanoreaction Vials



Reactants encapsulated in single liposome or in 2 separate liposomes and fused



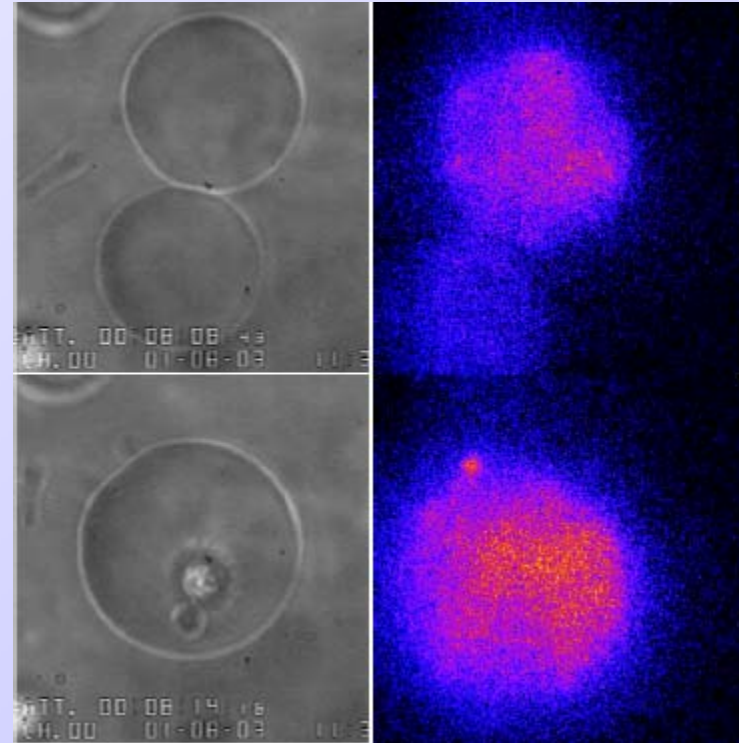
Independently controllable environment, study reaction kinetics, single molecule events

Liposomes

Nanochannels

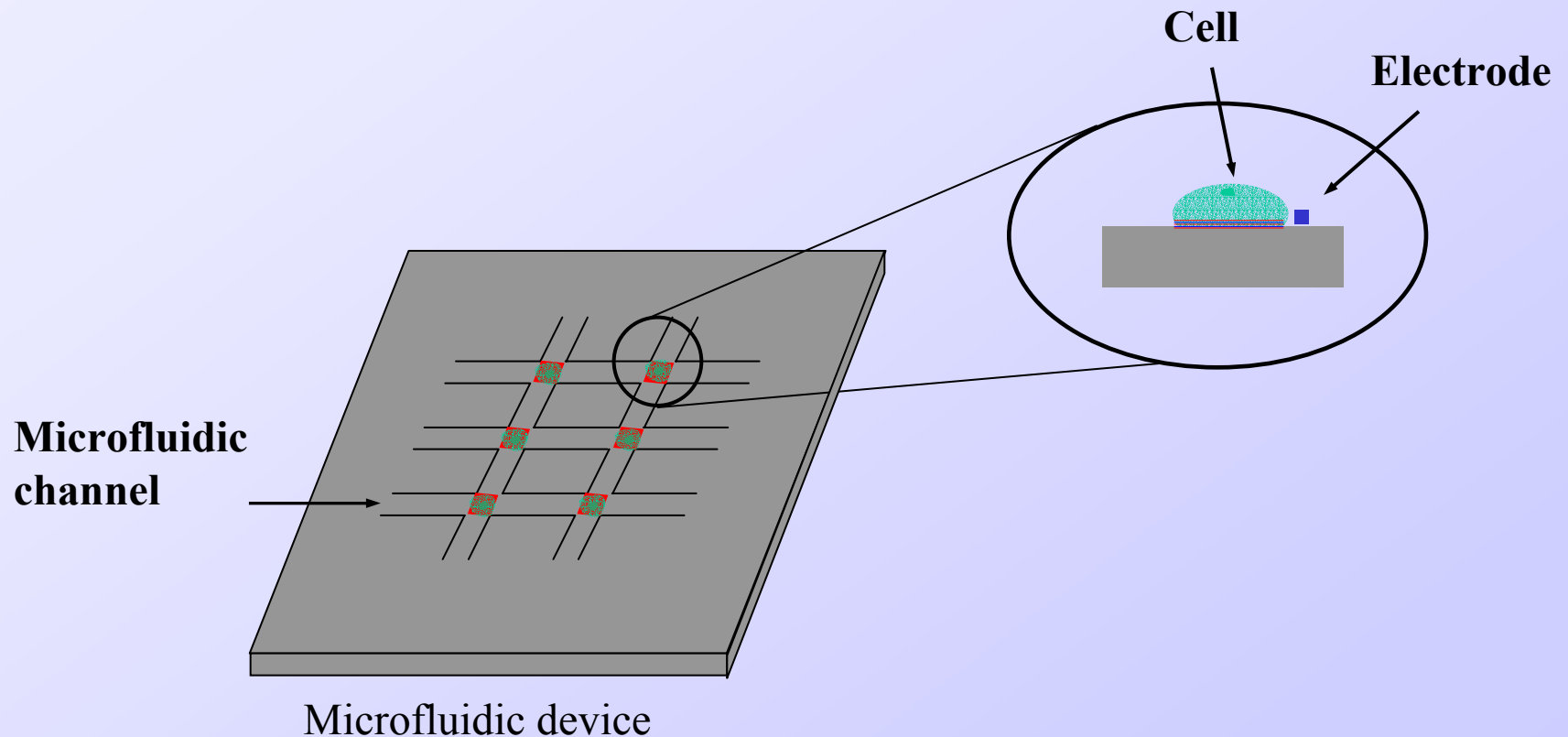


Pull a nanochannel from a liposome

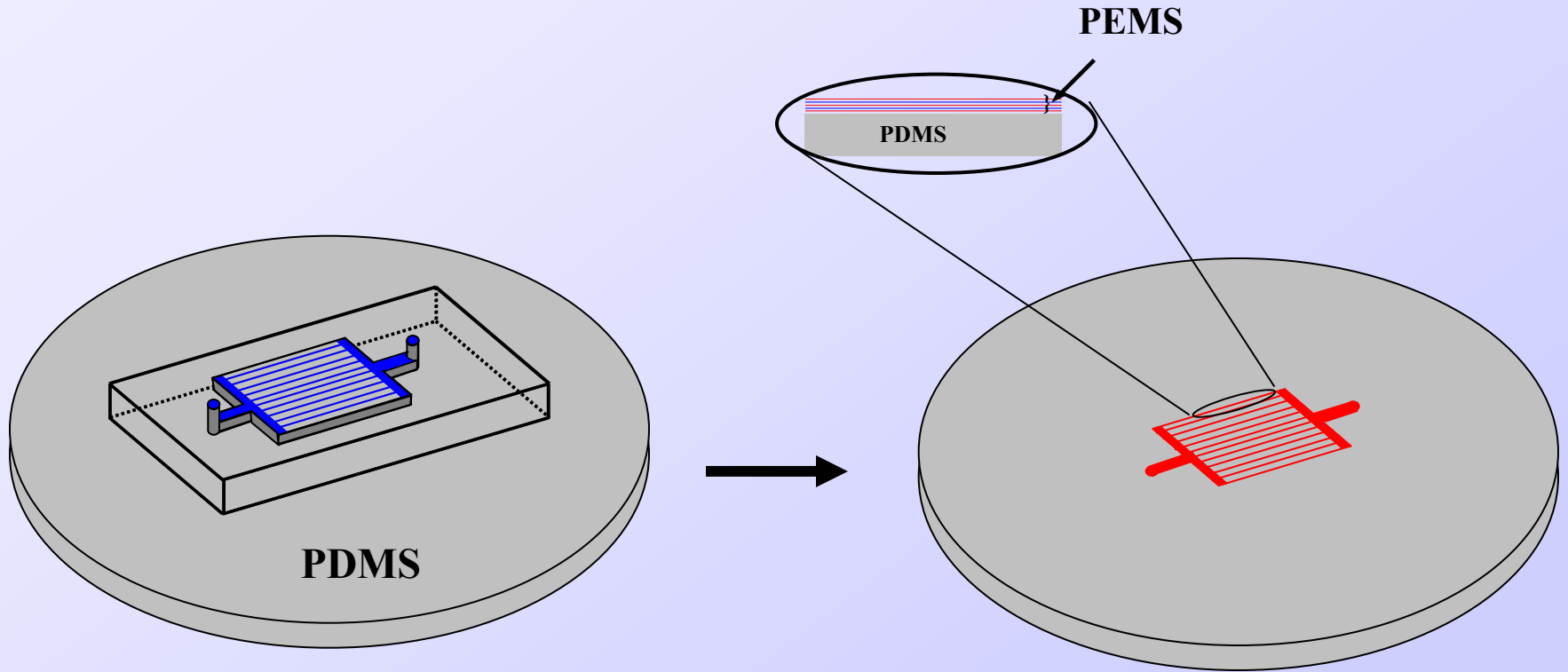


Independently controllable
environment, study reaction
kinetics, single molecule events

Cellular BioElectronic Interfaces



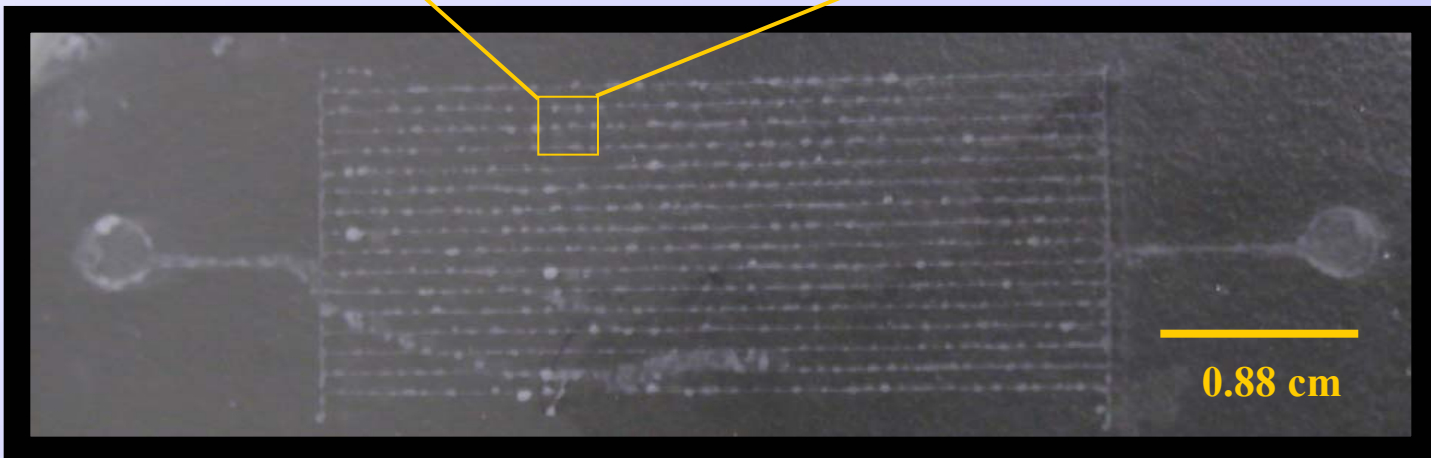
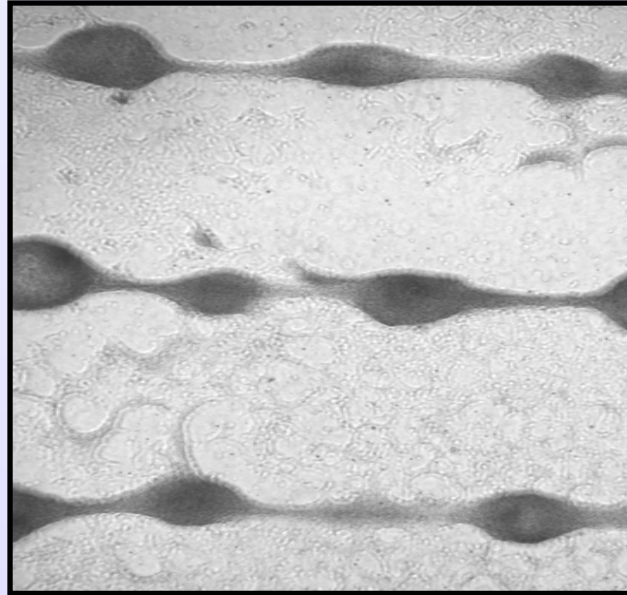
Patterning PDMS with PEMS



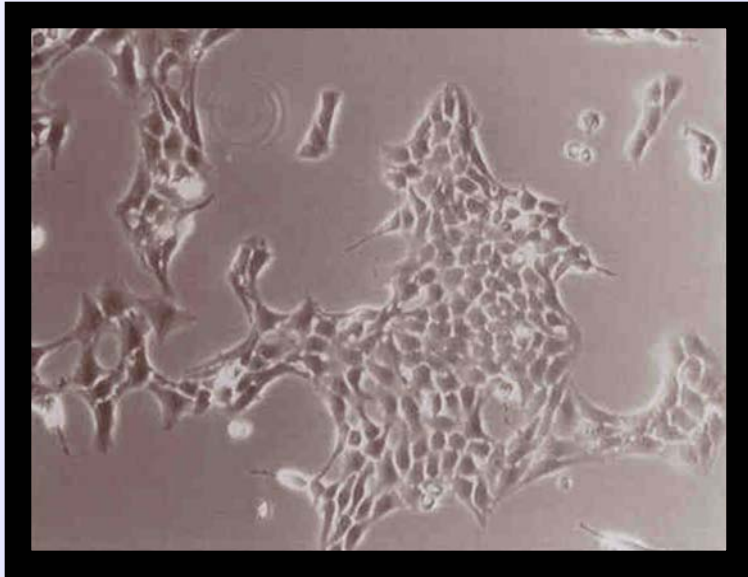
Polyelectrolyte Multilayers (PEMS)

Polydimethylsiloxane (PDMS)

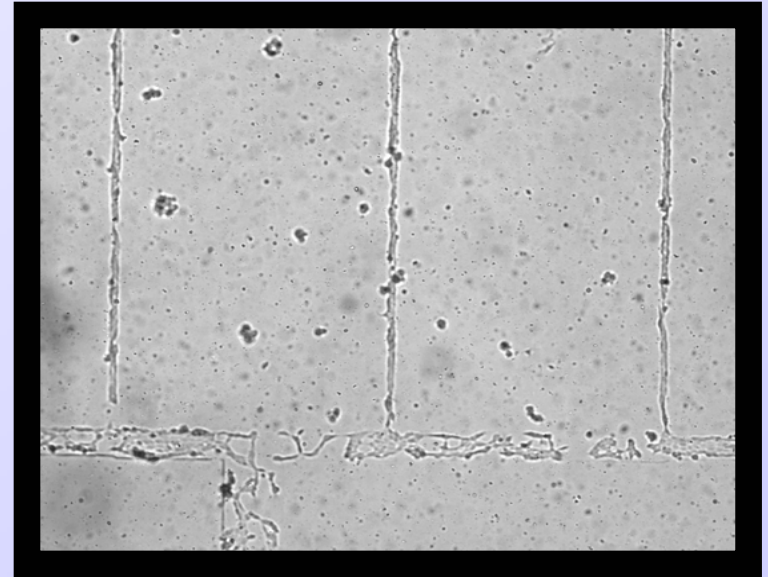
Two weeks growth of retinal cells on poly(ethyleneimine).
Cells are covering all the polycation area.



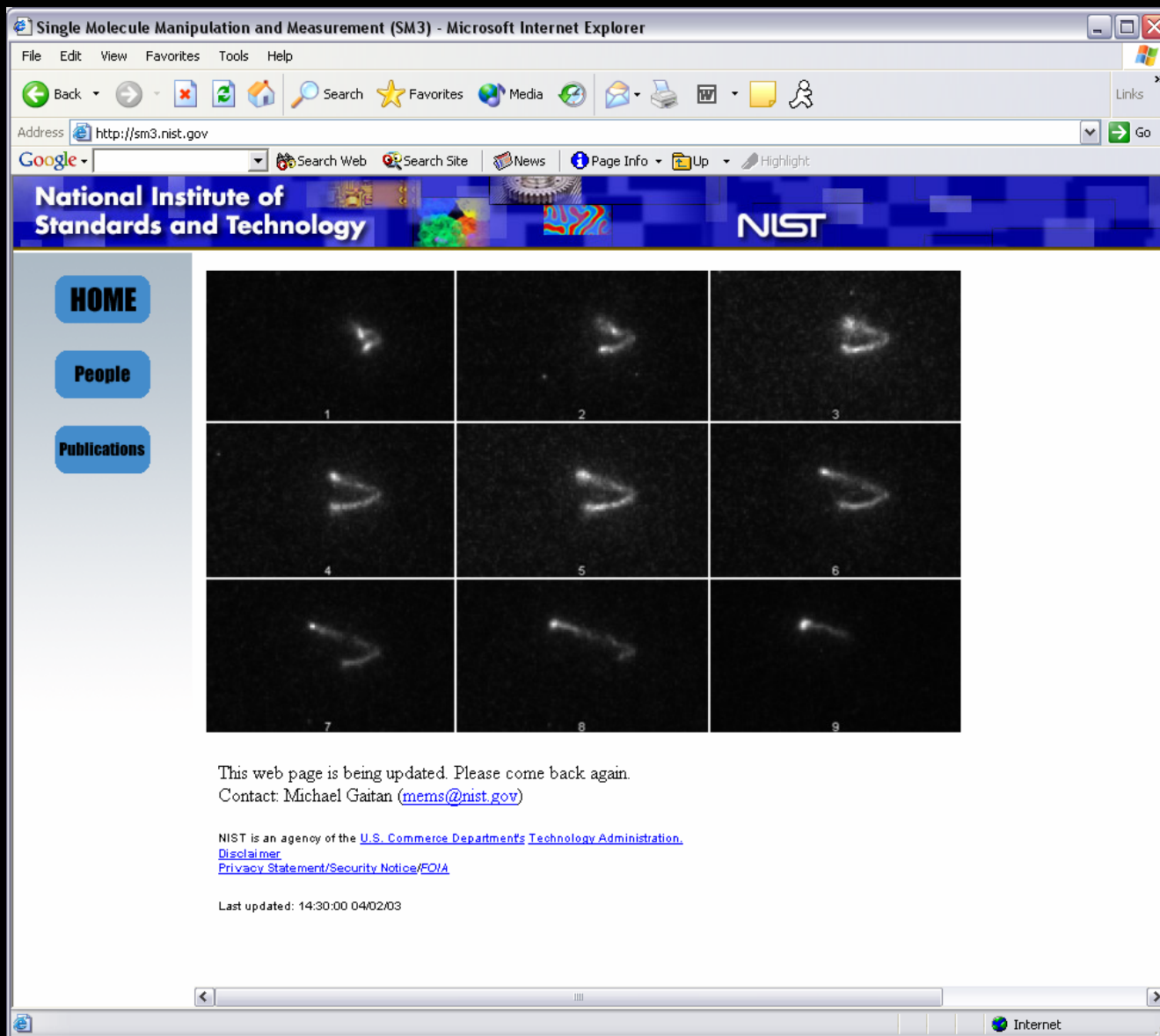
Non-Patterned Cell Growth vs. Patterned Cell Growth



Retinal cells cultured in polystyrene culture flasks.



Overnight growth of retinal cells on poly(allylamine hydrochloride) patterned lines.



<http://sm3.nist.gov>